

# *The Installation and Commissioning of the IPNS Third Cavity*

## *The Fourth CW and High Average Power RF Workshop*

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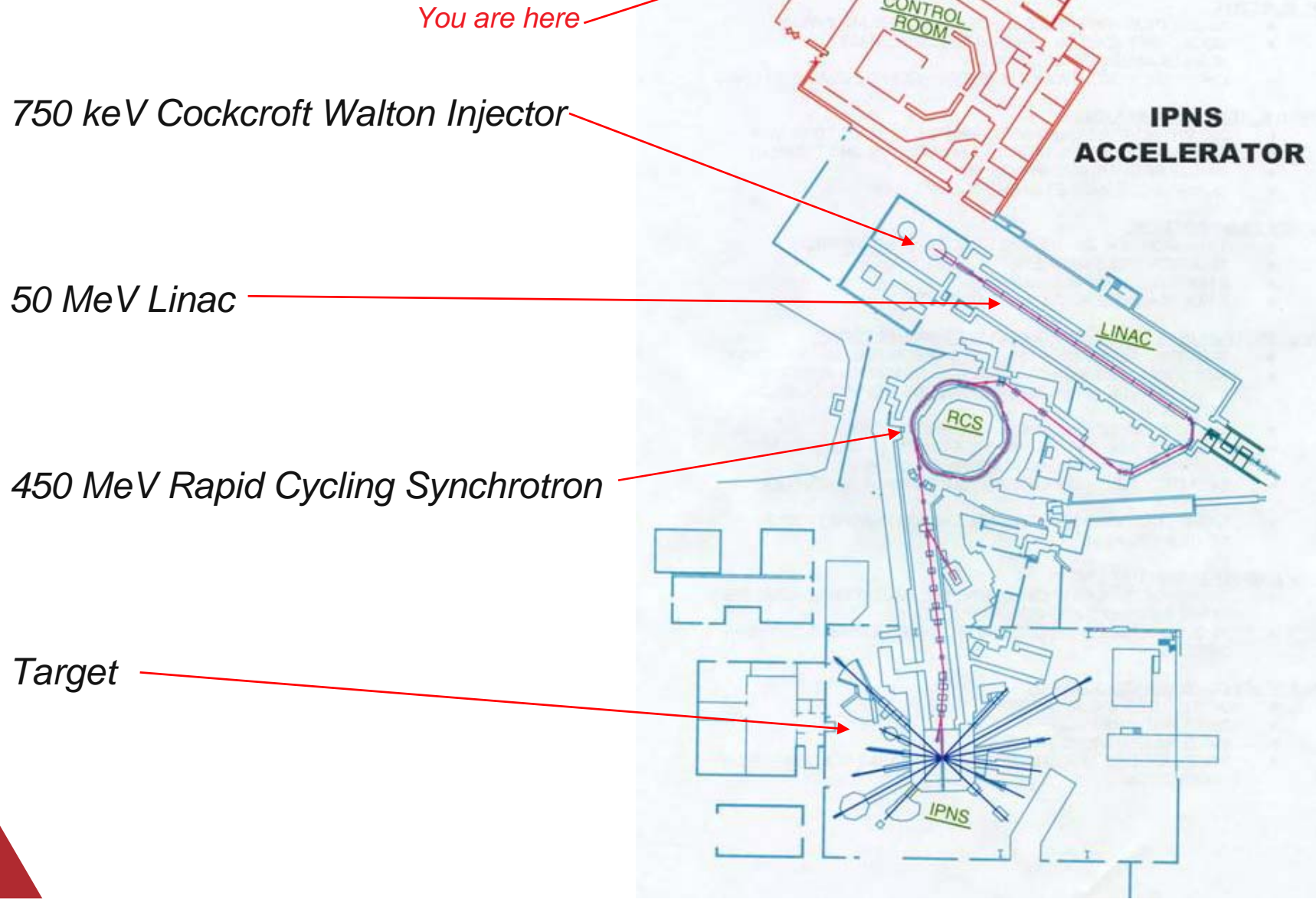
*Douglas Horan  
APS, ANL*

*Ali Nassiri  
APS, ANL*

*Robert Zolecki  
IPNS, ANL (Retired)*



# Intense Pulsed Neutron Source



## Outline

- Motivation
- Description of the Original IPNS RCS RF System
- Description of the Third Cavity RF System
- Installation and Commissioning of the Third Cavity RF System
- Plans for Operating Third Cavity at the Second Harmonic



## Motivation

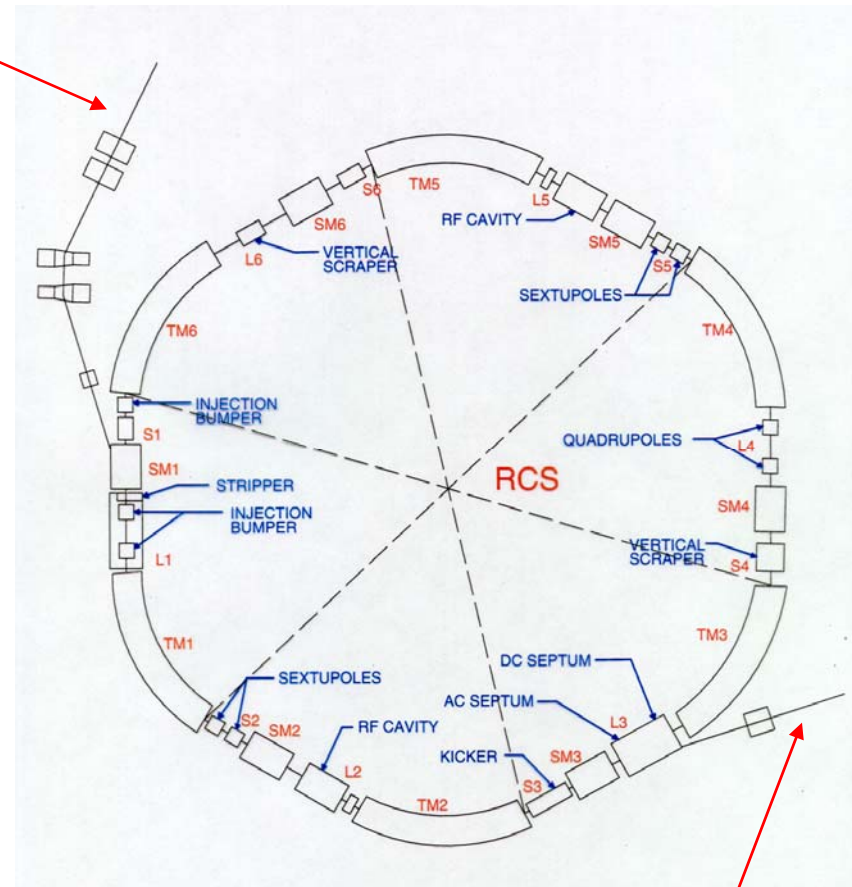
- Early indications suggested that the RF system was voltage limited.
- A third cavity would provide operational flexibility and possibly contribute to increased reliability.
- A third cavity would provide a platform for 2<sup>nd</sup> harmonic studies.



## Original RCS RF System: RCS Machine Parameters

- Circumference = 42.9 m
- $f_{inj} \sim 2.21$  MHz,  $E_{inj} = 50$  MeV
- $f_{ext} \sim 5.14$  MHz,  $E_{ext} = 450$  MeV
- $\sim 3.7 \times 10^{12}$  protons injected
- $\sim 3.2 \times 10^{12}$  protons extracted
- Harmonic number = 1
- Repetition rate = 30 Hz
- Typical average beam current  $\sim 15$  uA
- Cavities located in the L2 and L5 straight sections
- $\sim 21$  kV total accelerating voltage w/2 cavities

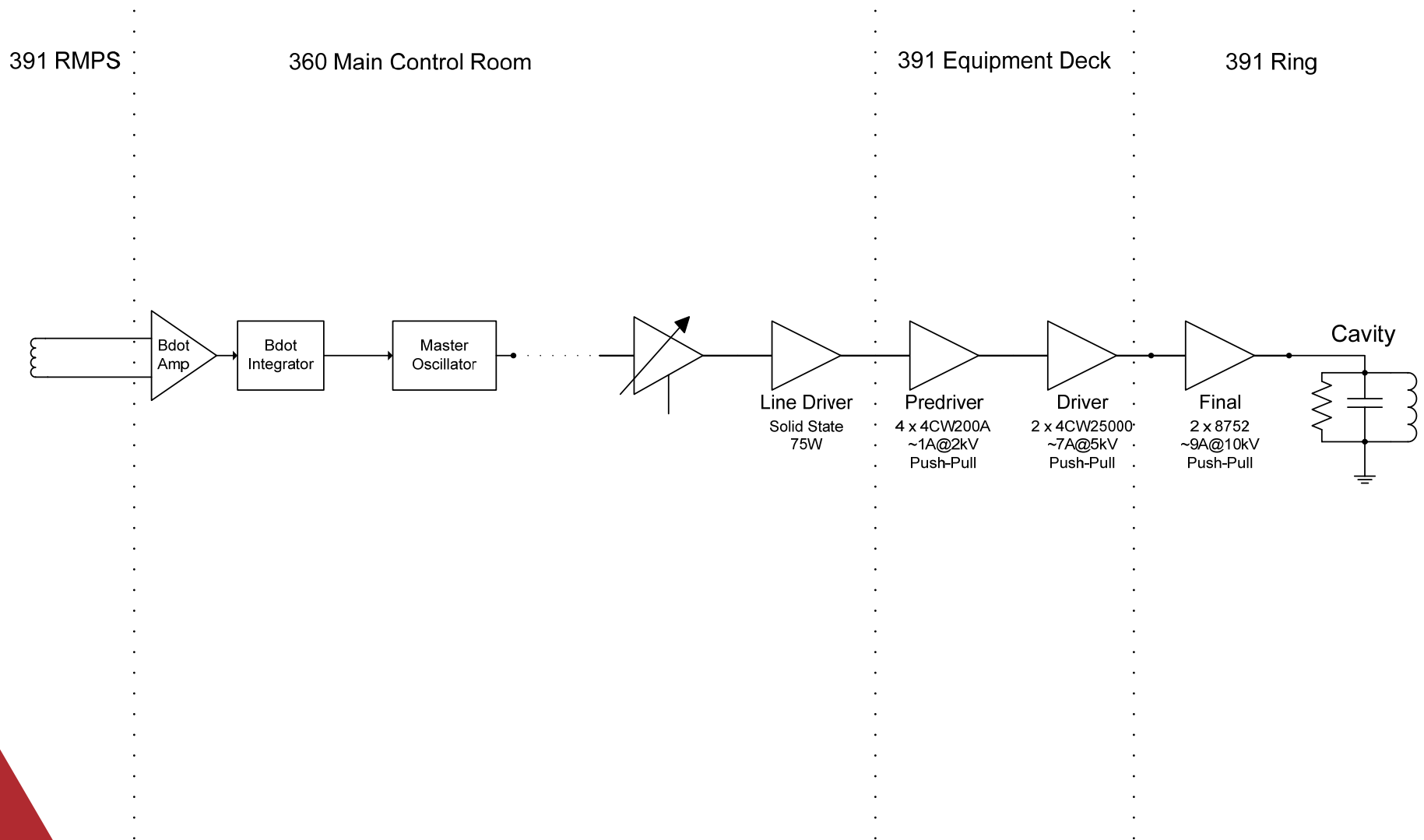
Injection Line



Extraction Line

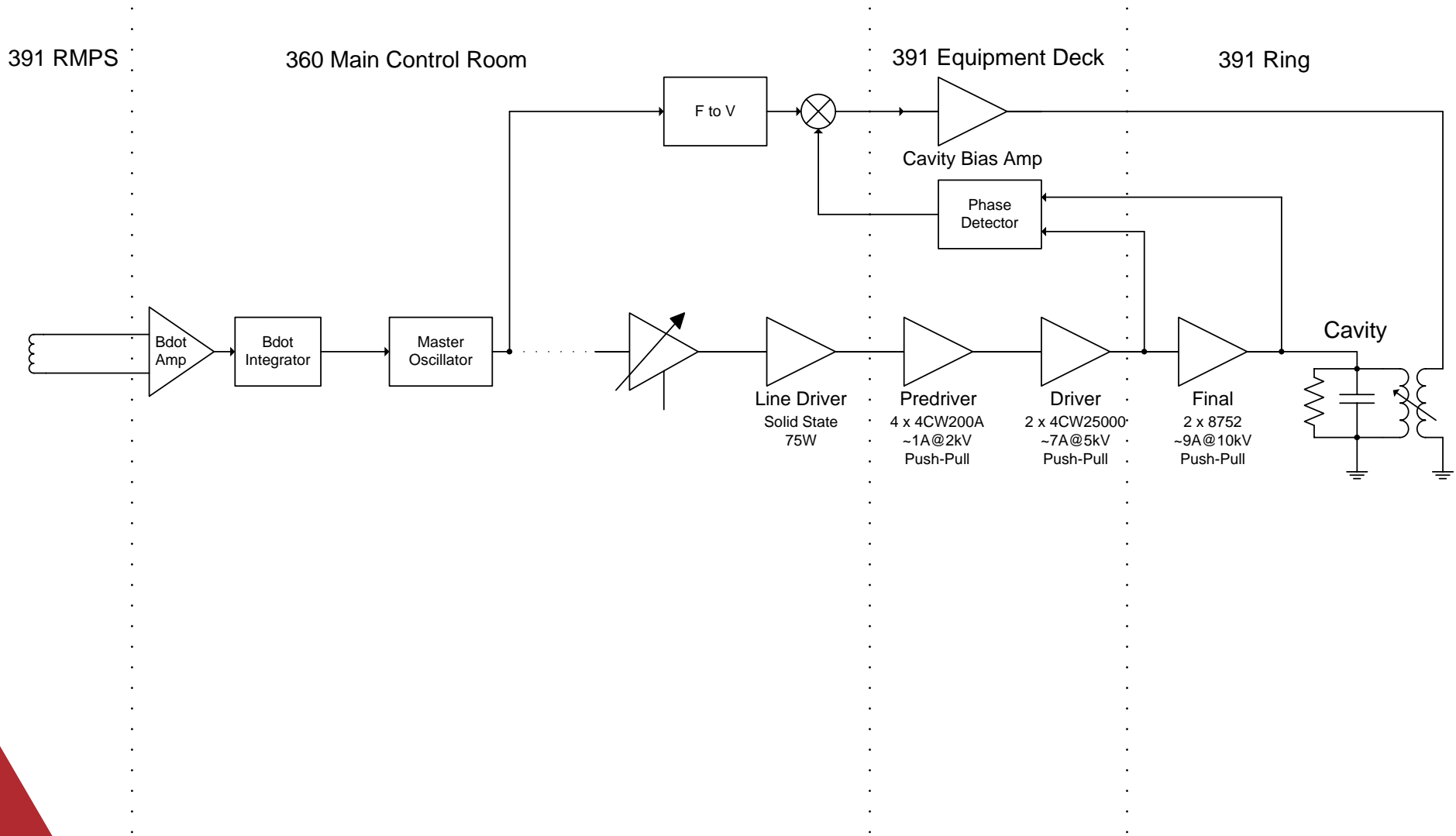
# Original RCS RF System: Typical RF System

- Amplifier Chain



# Original RCS RF System: Typical RF System

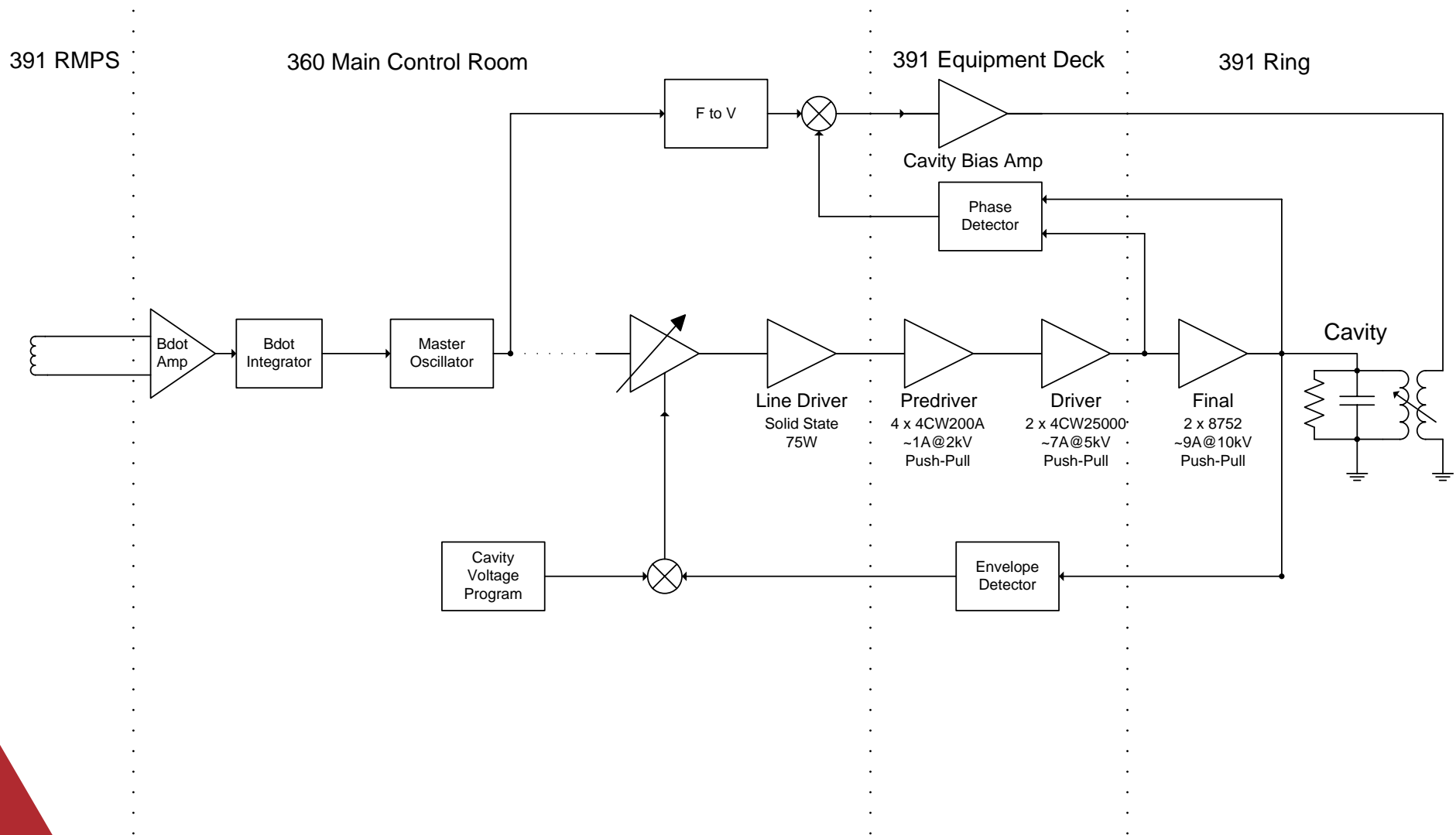
- Cavity Tuning





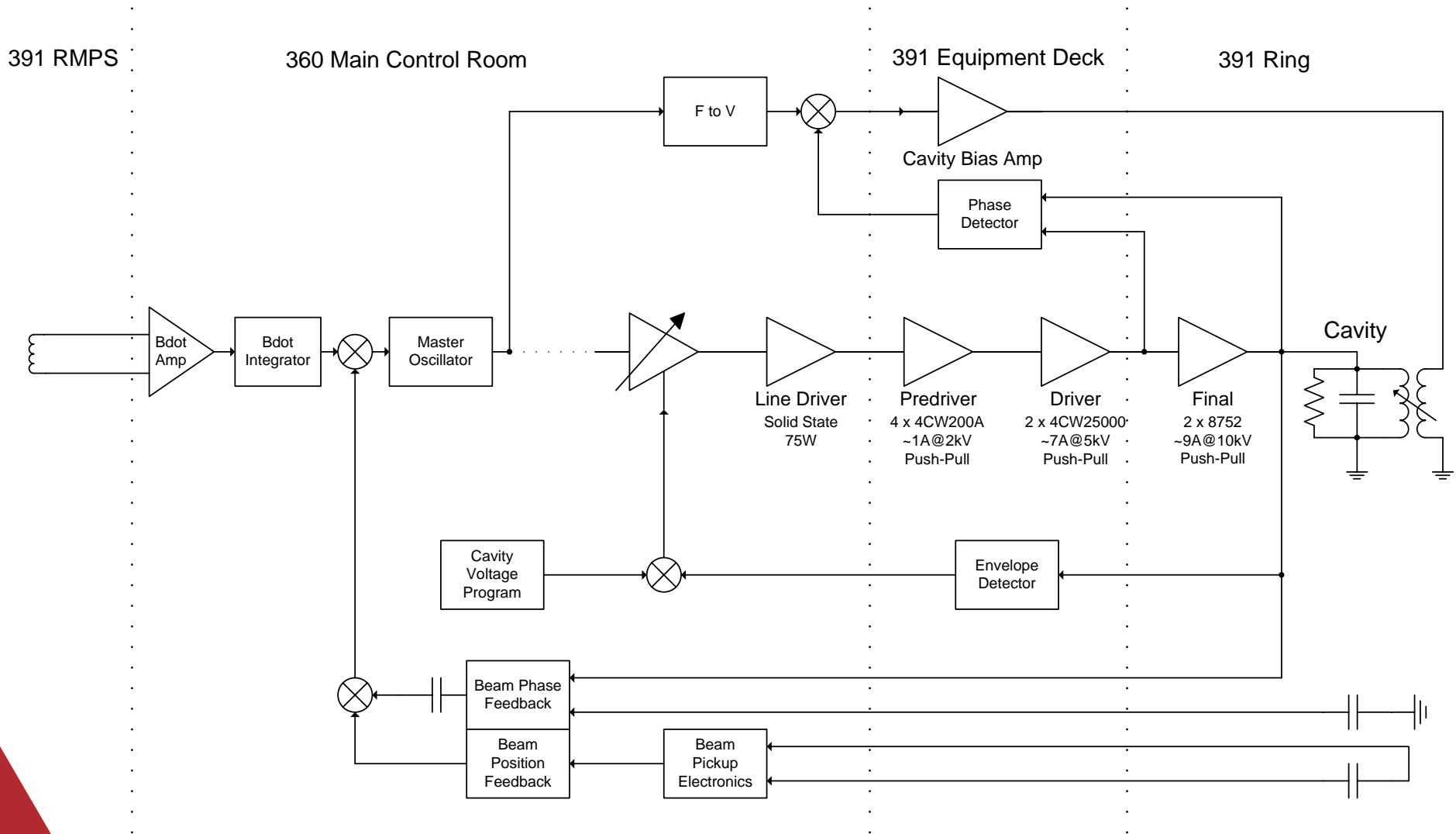
# Original RCS RF System: Typical RF System

- Amplitude Control



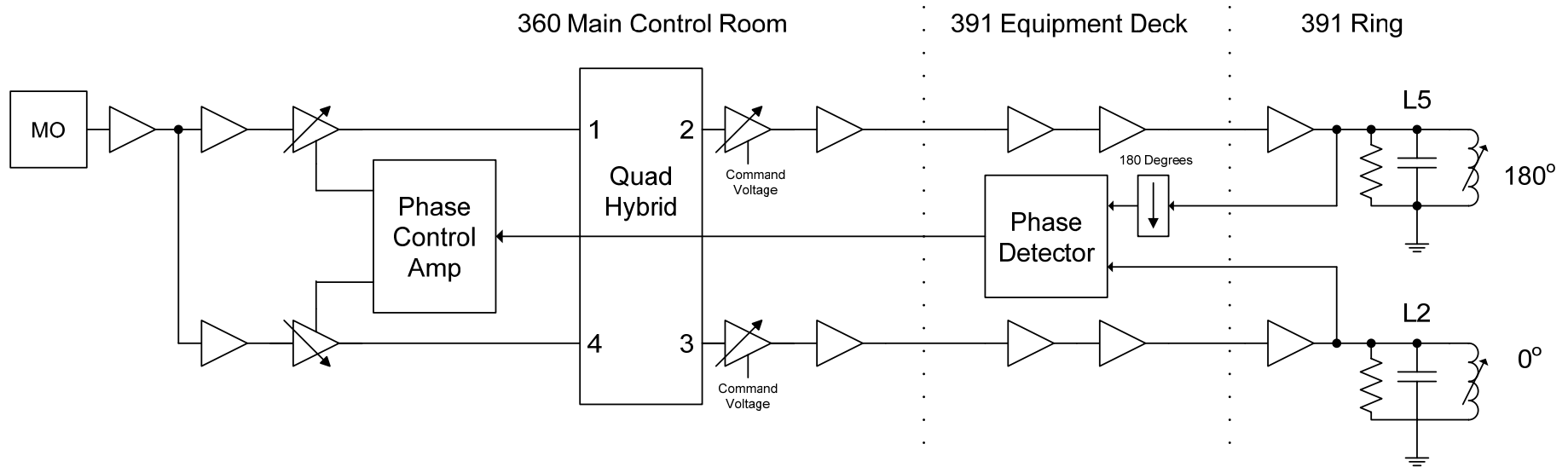
# Original RCS RF System: Typical RF System

- Beam Position and Phase Control



## Original RCS RF System: Typical RF System

- Cavity to Cavity Phase Control



## Original RCS RF System: Typical RF System

- Low Level RF Electronics

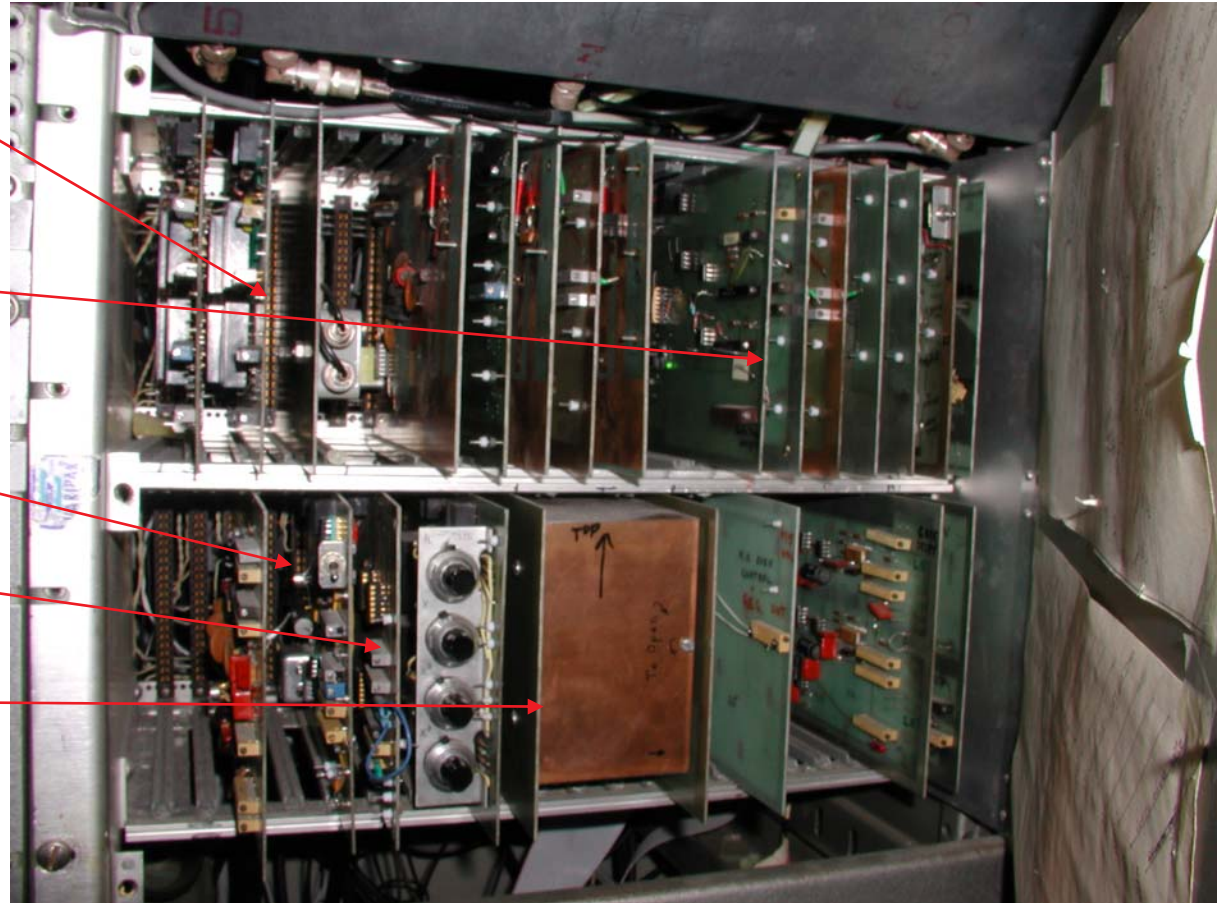
• Cavity to cavity phase control

• Amplitude control

• Bdot integrator

• B offset and scaling

• Master oscillator



## Original RCS RF System: Typical RF System

- Predriver, Driver and Cavity Bias Supply



- **Predriver/Driver Cabinet**
- **Predriver Plate Supply, ~1A@2kV**
- **Driver Plate Supply, ~7A@5kV**



## Original RCS RF System: Typical RF System

- Predriver, Driver and Cavity Bias Supply

- Cavity Bias Supply,  
0 – 1000A, 30VDC

- Grid and Screen Supplies,  
Interlock Status and Control

- Predriver/Driver Cabinet



## Original RCS RF System: Typical RF System

- Final Plate Supply (the “Reeves”)
- Single Supply provide plate voltage to L2 and L5 finals.
- ~18A@10kV total.



## Original RCS RF System: Typical RF System

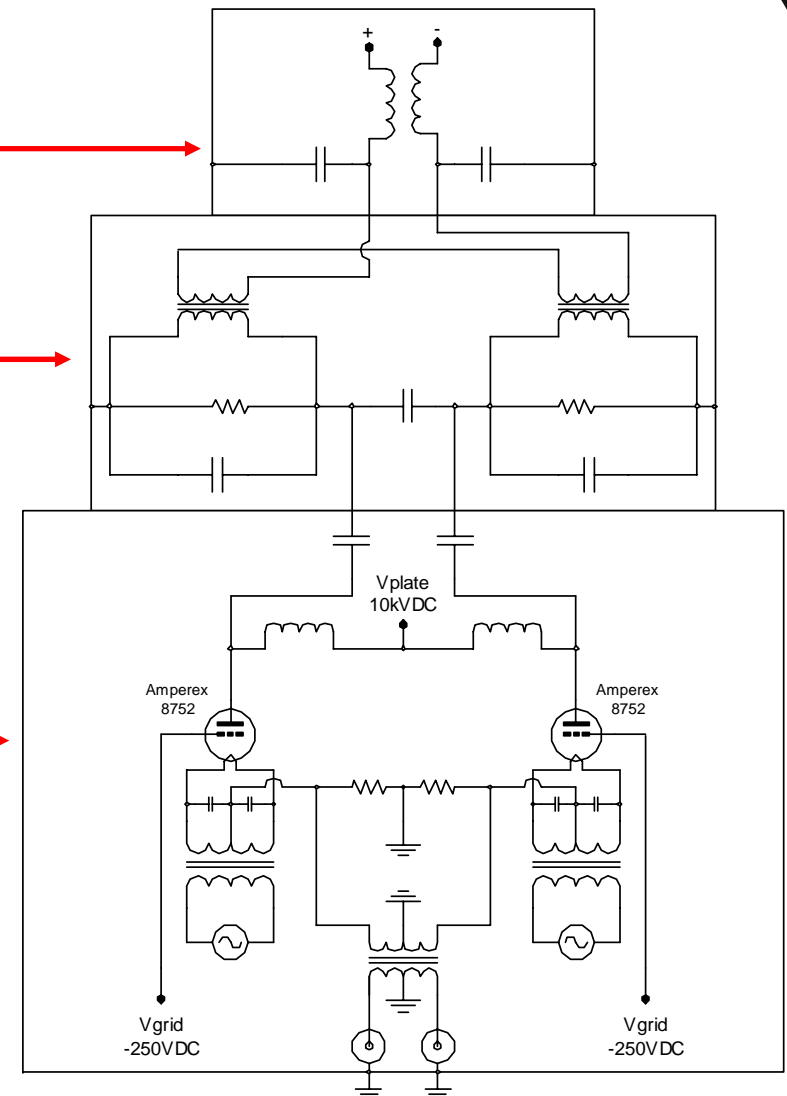
- Final, Cavity and Cavity Bias Choke Box



Choke Box

Accelerating  
Cavity

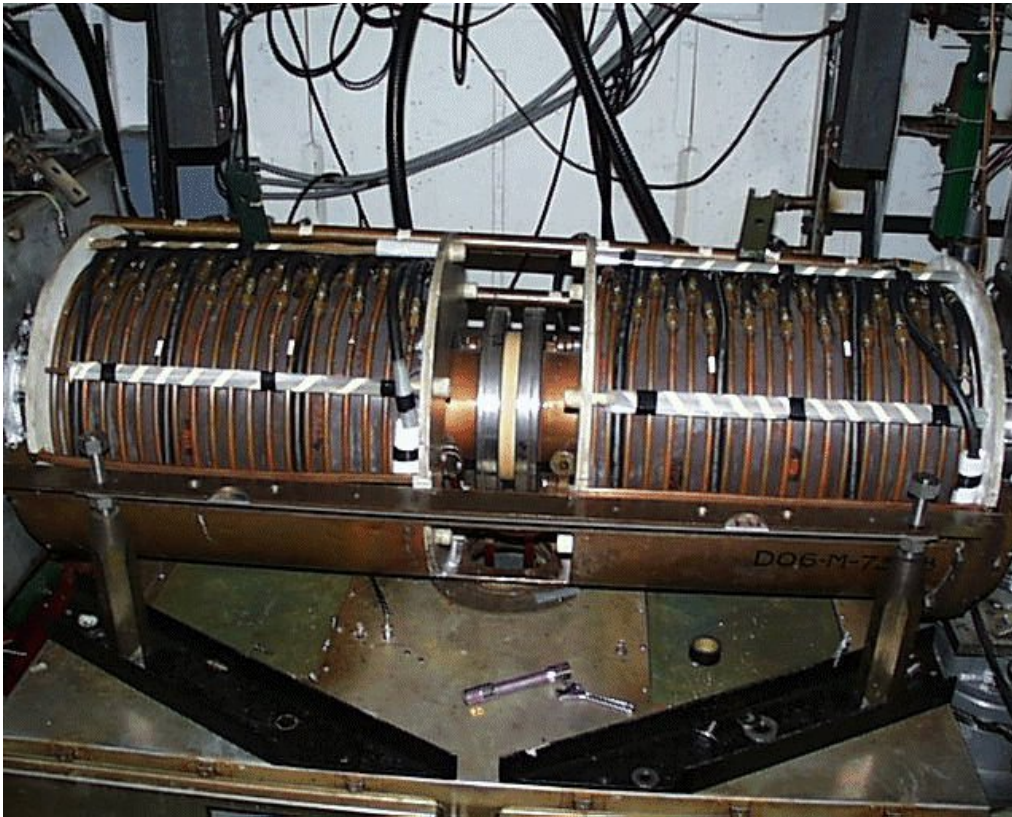
Final  
Amplifier





## Original RCS RF System: Typical RF System

- Ferrite-Loaded, Coaxial Cavity



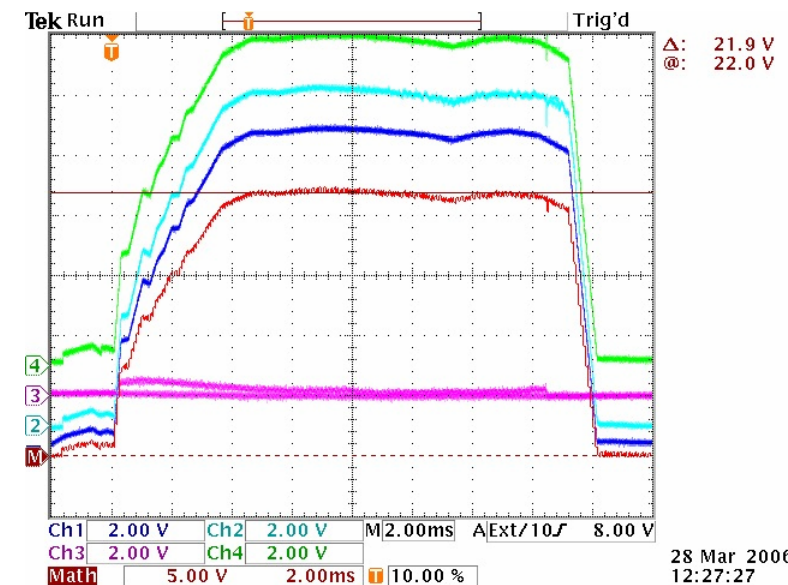
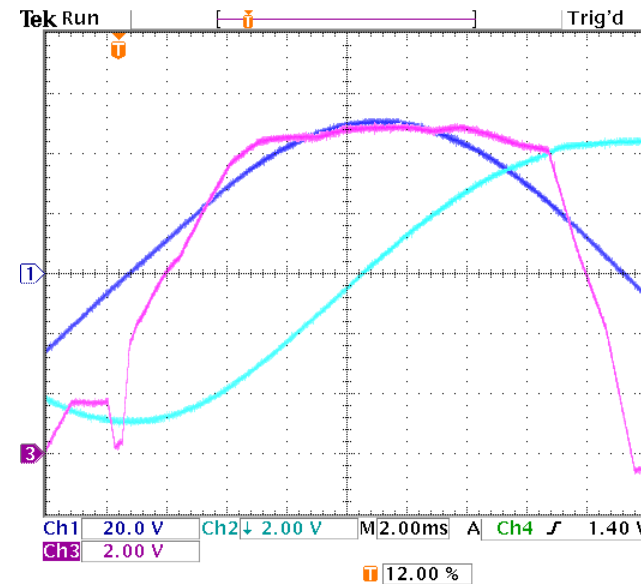
- Cavities are ferrite-loaded, coaxial structures, with the accelerating gap in the center.

- Cavities are tuned by magnetic biasing of the ferrite.
- Each cavity contains two ferrite stack modules that are each ~20 inches long and ~14 inches in diameter.
- Each stack is made up of 20 Philips type 4H ferrite torroids ( $\mu \sim 350$ ), with edge-cooled copper cooling disks, insulating end pieces.
- Two figure-eight, parallel-connected, water-cooled conductors provide for biasing.
- The gap is formed by a ceramic spacer shunted with glass-vacuum capacitors.
- The cavity is a balanced device and driven push-pull.



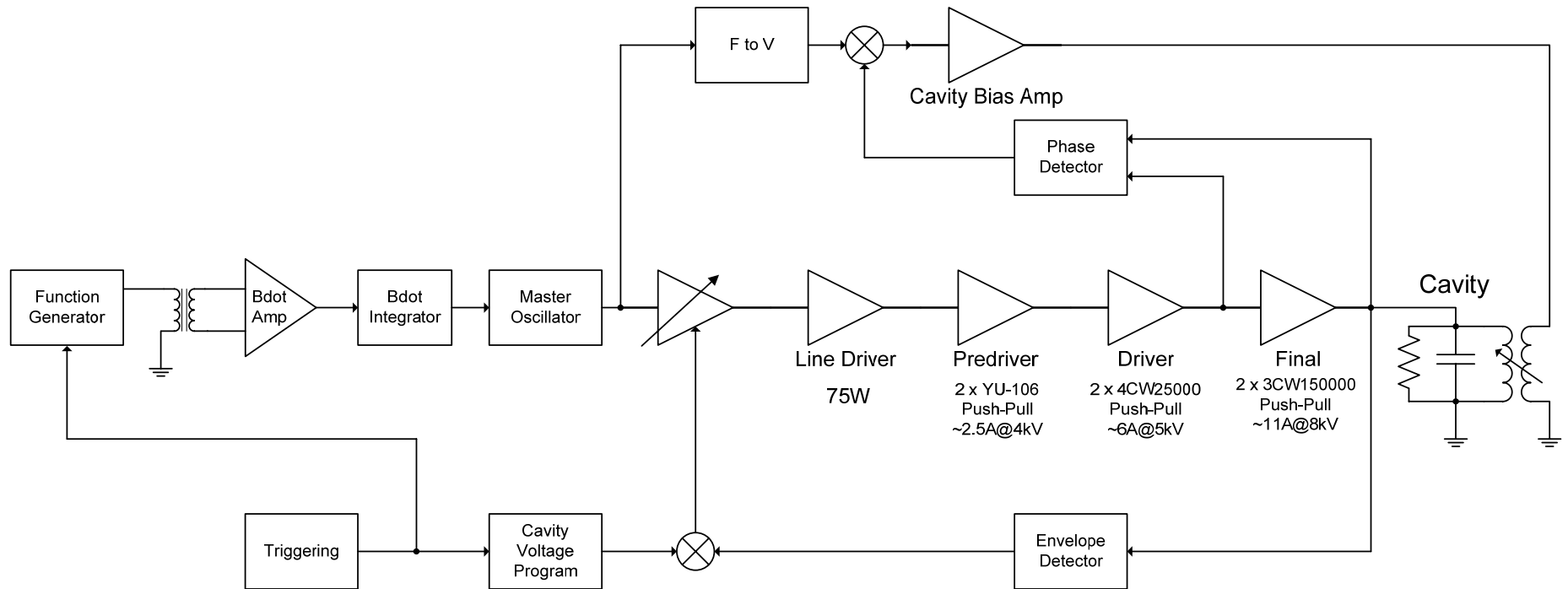
## Original RCS RF System: Typical RF System

- Typical Two Cavity Operation
- Cavity gap voltages are driven at RF frequency which is modulated from ~2.21 MHz at injection, to ~5.14 MHz at extraction.
- Cavity gap voltages are amplitude modulated from a few hundred volts at injection, to ~10kV per gap at Bdot max.



## The Third Cavity RF System

- Third Cavity Test Stand



# The Third Cavity RF System

- Time Line

**June 1 – 16, 2005:**

**Two week around-the-clock operation in swept-frequency mode at ~11kV gap voltage.**

**June 17 – August 15, 2005:**

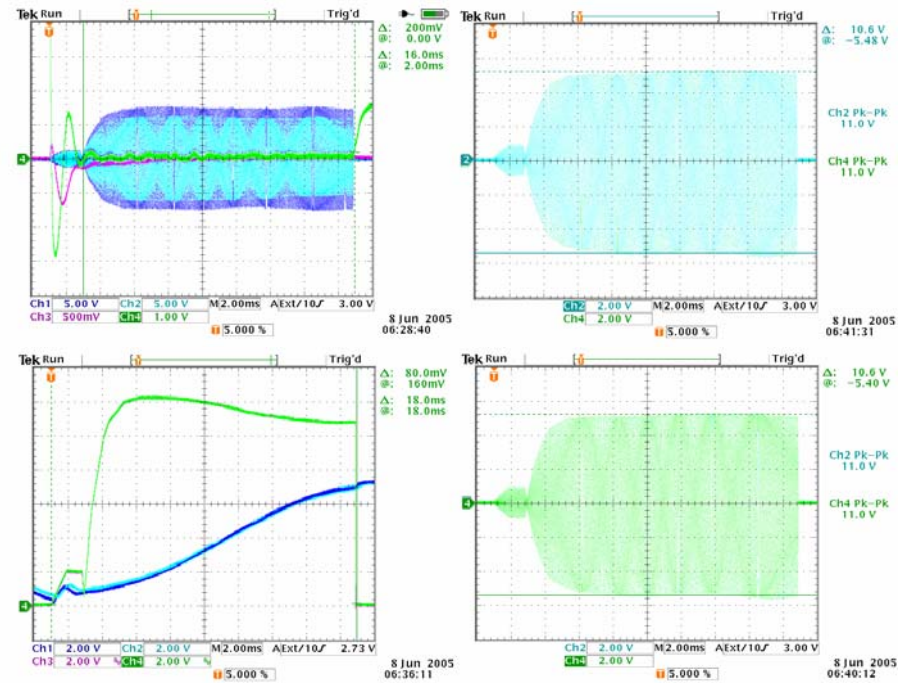
**Disassembled equipment and moved major components into place.**

**August 16, 2005:**

**Typical operating schedule started after summer shutdown, limiting access to working areas.**



## OPERATING SCHEDULE - FY05 October 2004 - September 2005



## The Third Cavity RF System

- Construction Photos: Test Stand



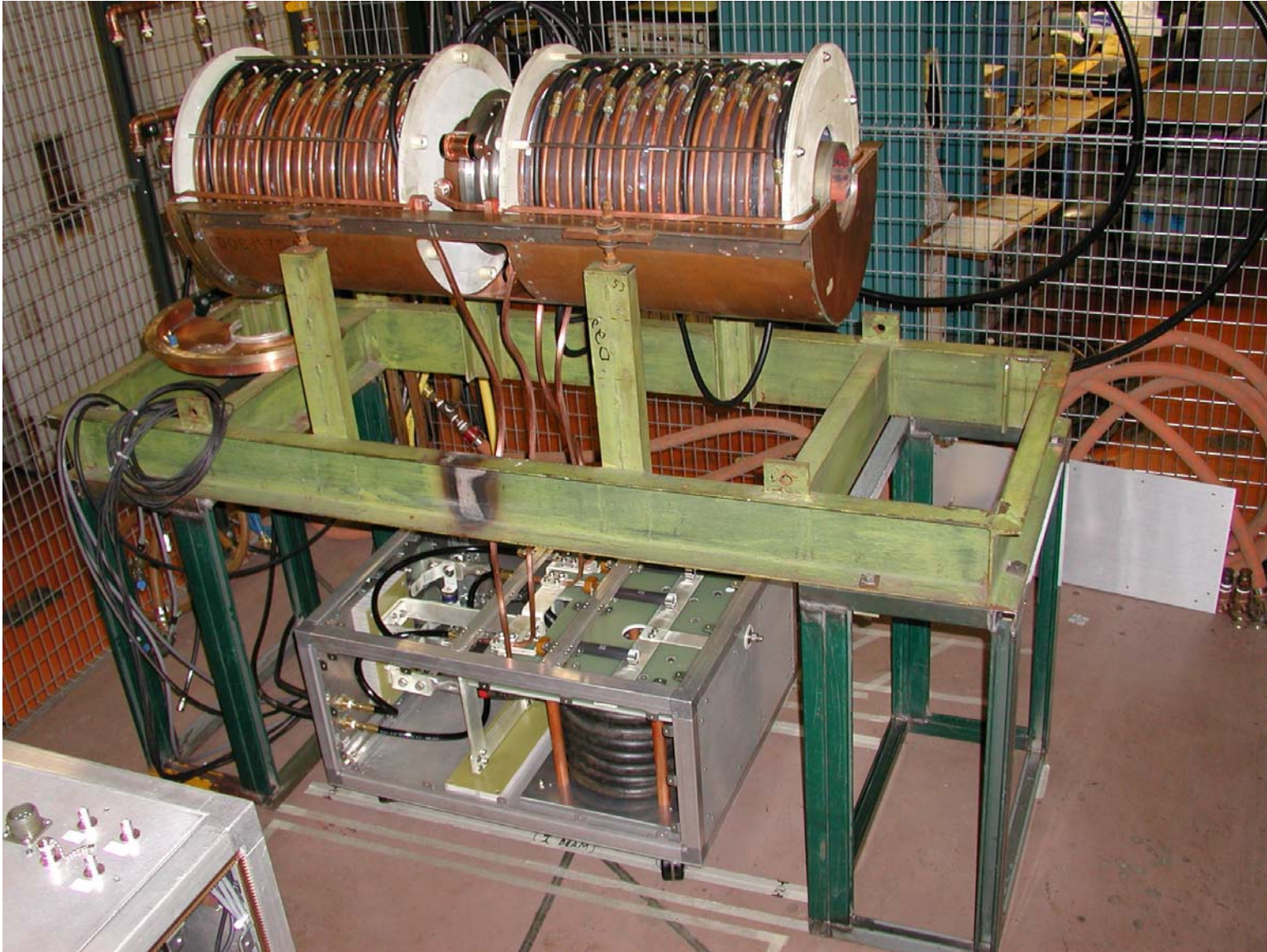
## The Third Cavity RF System

- Construction Photos: Test Stand



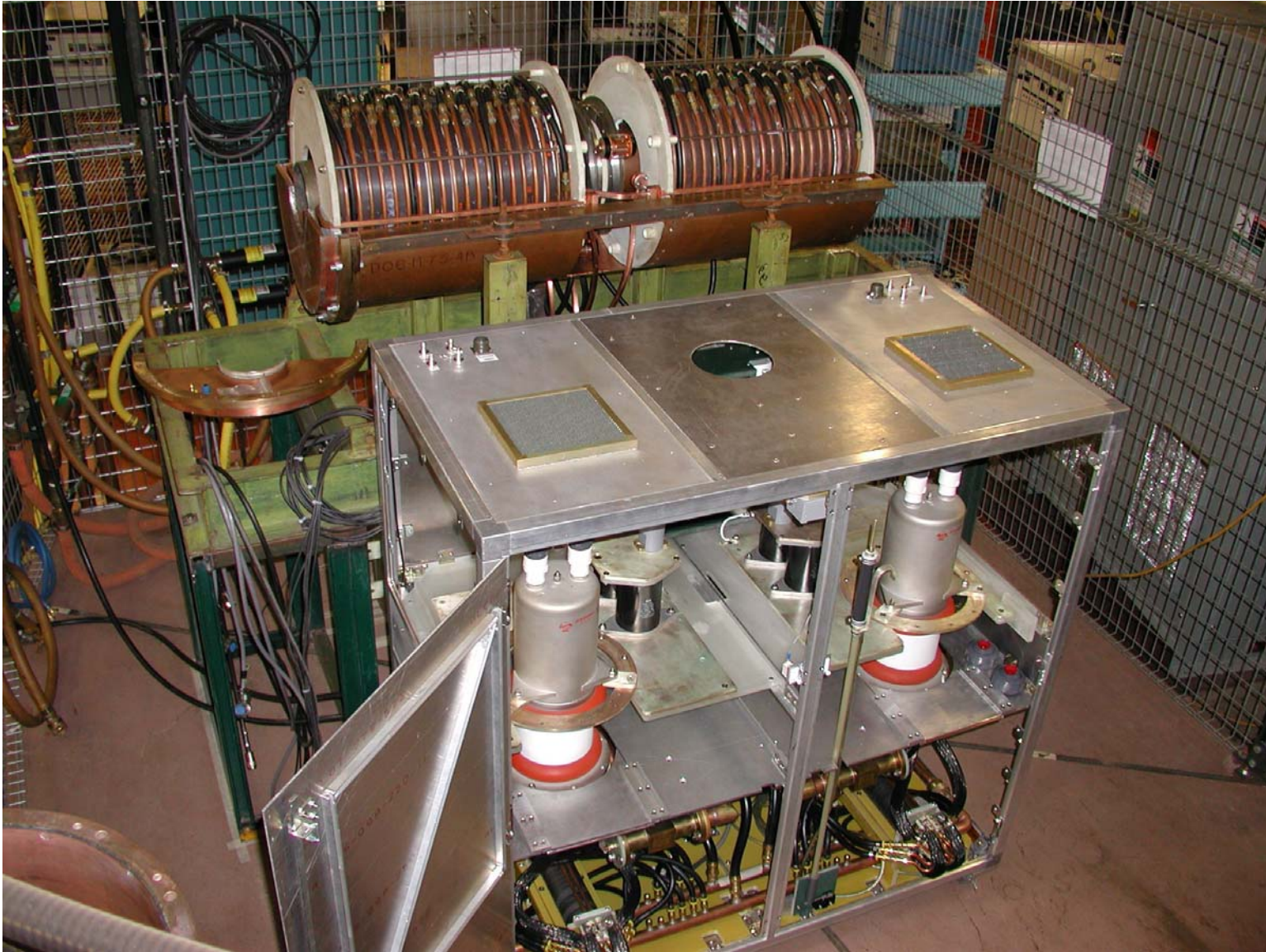
## The Third Cavity RF System

- Construction Photos: Test Stand



## The Third Cavity RF System

- Construction Photos: Test Stand





## The Third Cavity RF System

- Construction Photos: Test Stand



## The Third Cavity RF System

- Predriver and Driver

- Amplitude and Phase Detection Electronics

- Driver

- Predriver



## The Third Cavity RF System

- Cavity Bias Supply, Final Grid and Filament Supply Cabinet
- Cavity Bias Supply, 0 – 1000A, 15VDC
- Final Grid and Filament Supply Cabinet



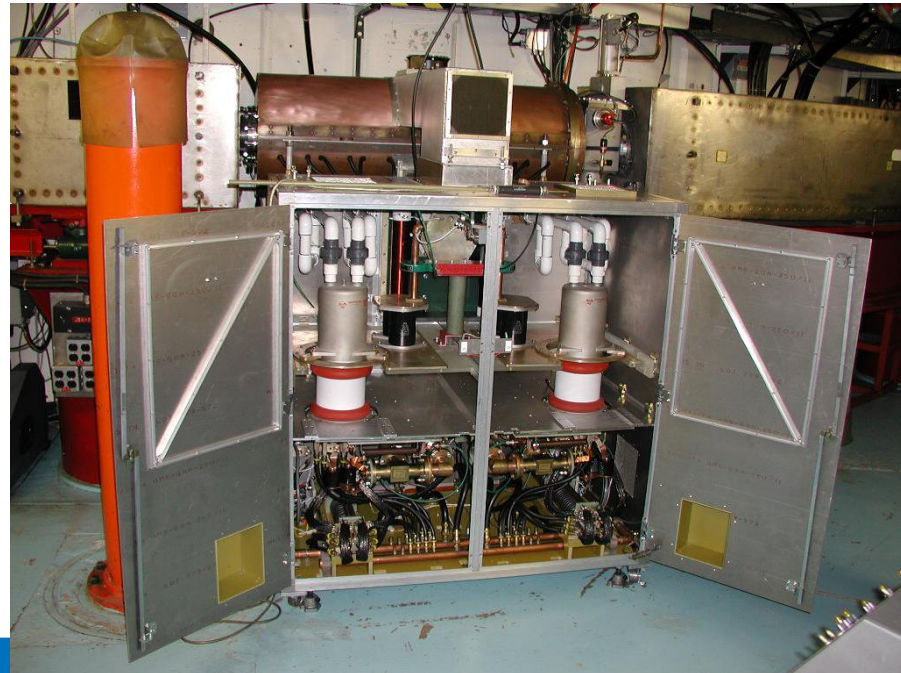
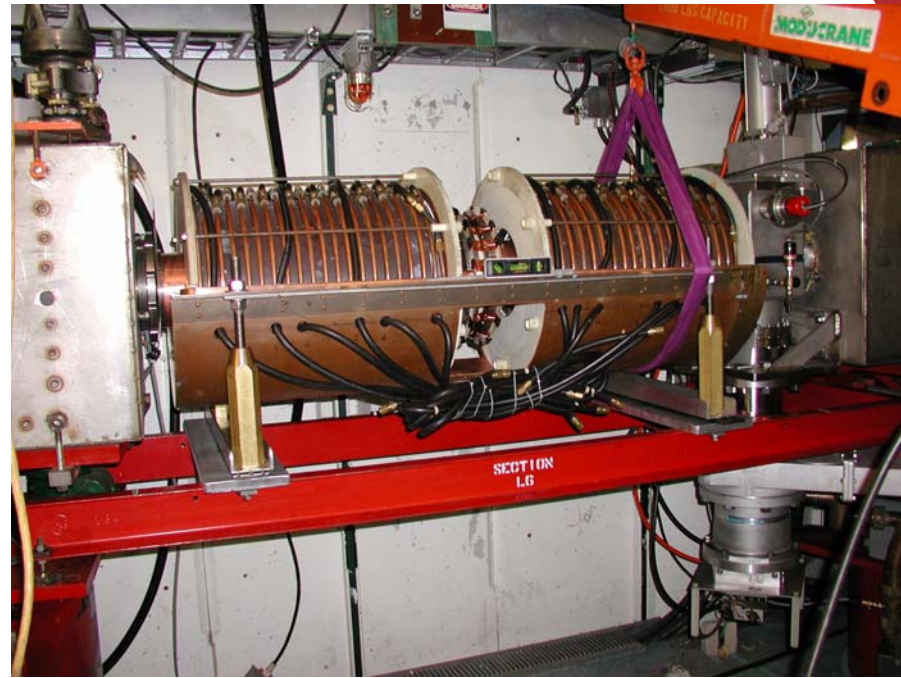
## The Third Cavity RF System

- “NWL” Final Plate Supply
- 24A@7kV or 12A@14kV T-R Set
- Modified to include soft start and crowbar



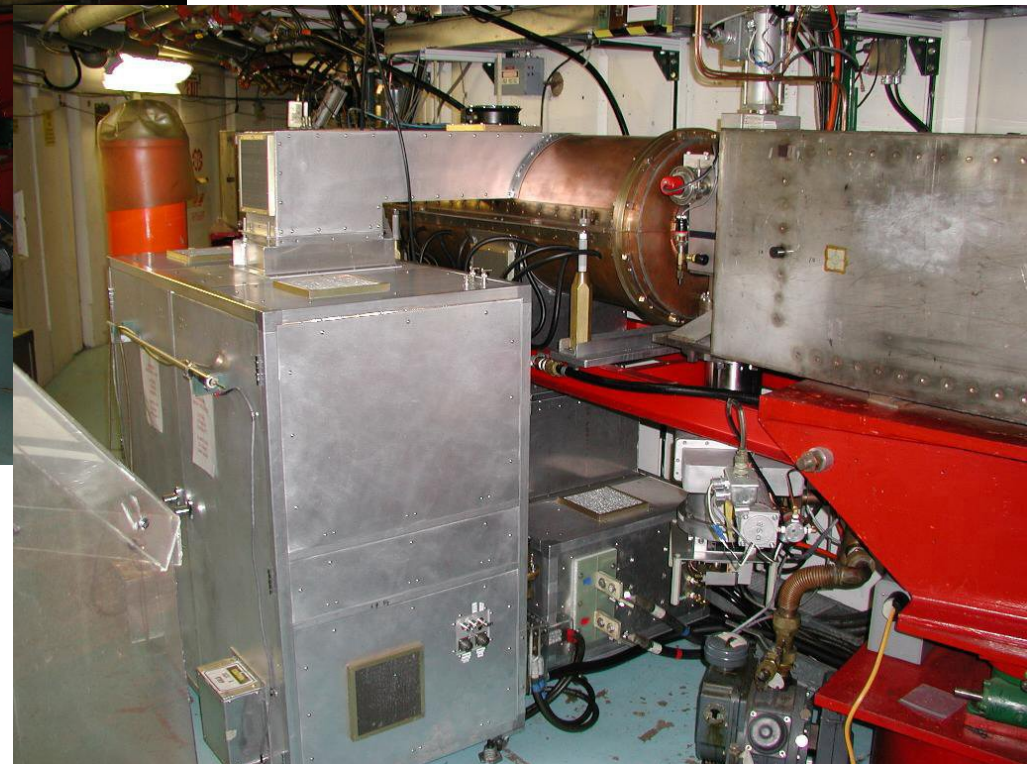
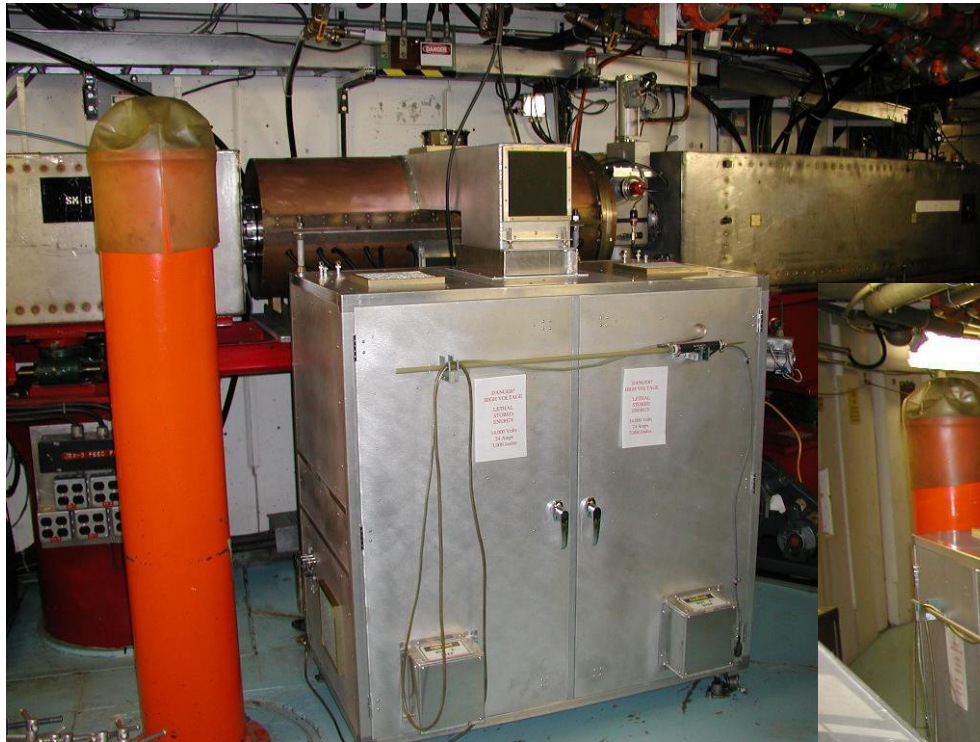
## The Third Cavity RF System

- Installation



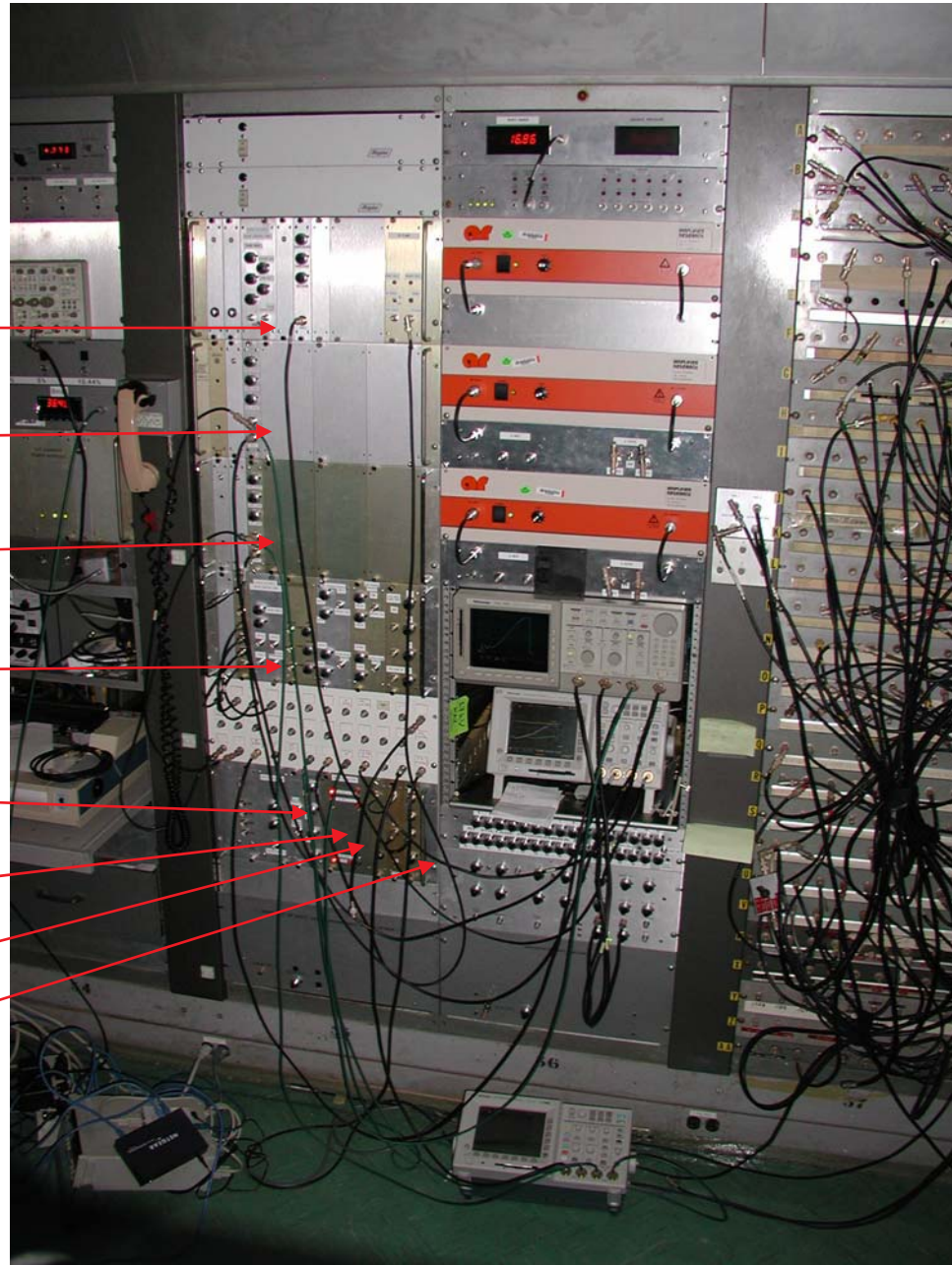
## The Third Cavity RF System

- Installation



## The Third Cavity RF System

- Low Level Electronics
- L6 Amplitude Control
- L5 Amplitude Control
- L2 Amplitude Control
- Cavity Phase Control
- Bdot Integrator
- B Offset and Scaling
- Master Oscillator
- Cavity Bias



# The Third Cavity RF System

- Time Line (continued)

**December 14, 2005 – February 3, 2006:**

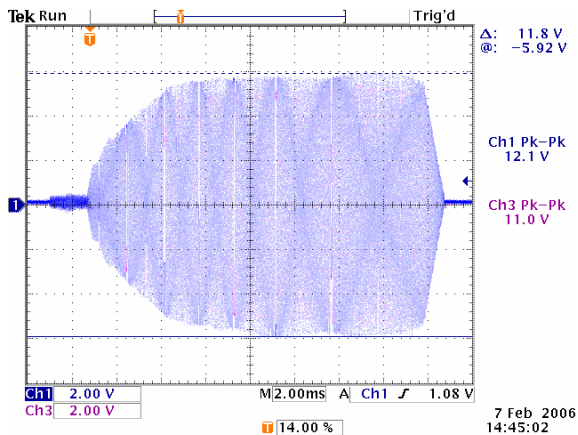
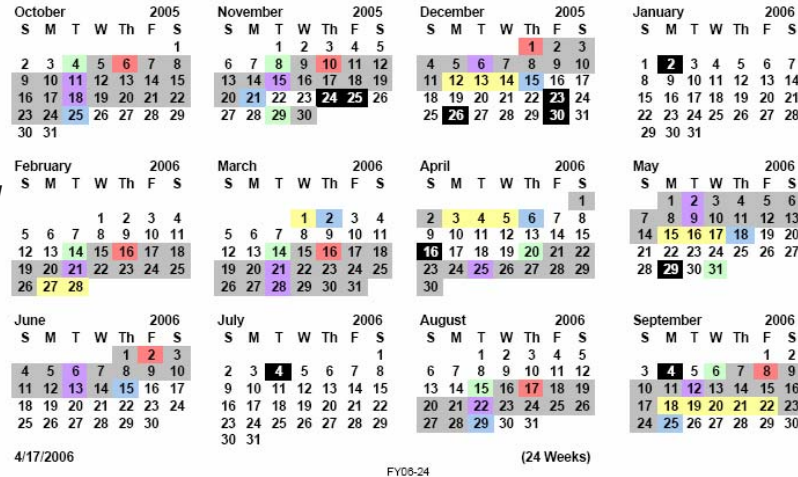
**Plumbed in utilities, pulled cables, checked interlocks, performed safety reviews, performed crowbar test, powered on equipment, checked out amplifiers.**

**February 7, 2006:**

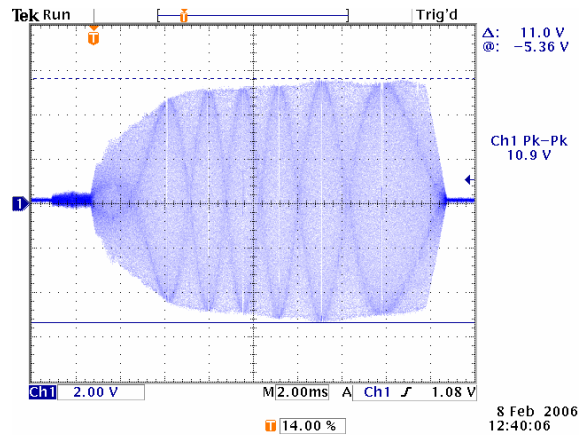
**Operated all three cavities in swept frequency mode to full voltage (> 30kV total) without L2-L6 cavity phase control.**

## IPNS OPERATING SCHEDULE - FY06 October 2005 - September 2006

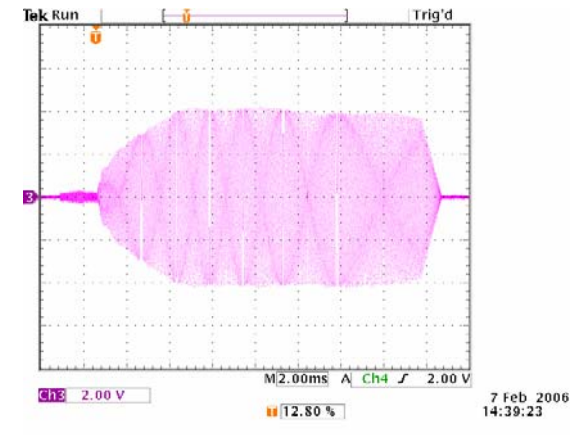
- Indicates Run Period
- Indicates Holiday
- Start-up 15:00
- Shutdown 10:00
- Machine Res. 09:00 - 11:00
- Machine Res. 09:00 - 15:00
- Machine Res. 07:30 - 15:30



L2 Cavity Upstream Gap Voltage, 1kV/volt



L5 Cavity Upstream Gap Voltage, 1kV/volt

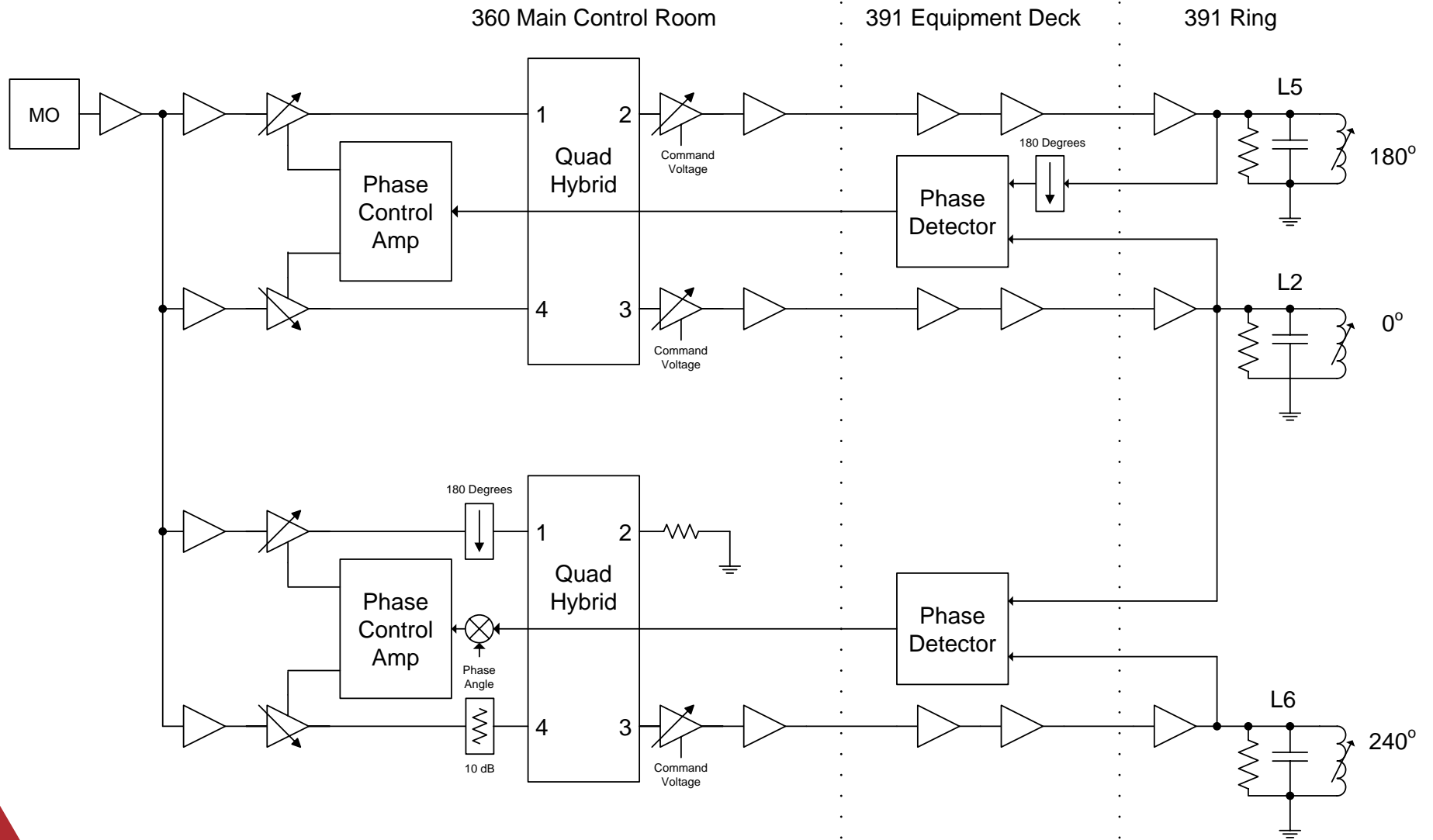


L6 Cavity Gap Voltage



# The Third Cavity RF System

- Cavity to Cavity Phase Control



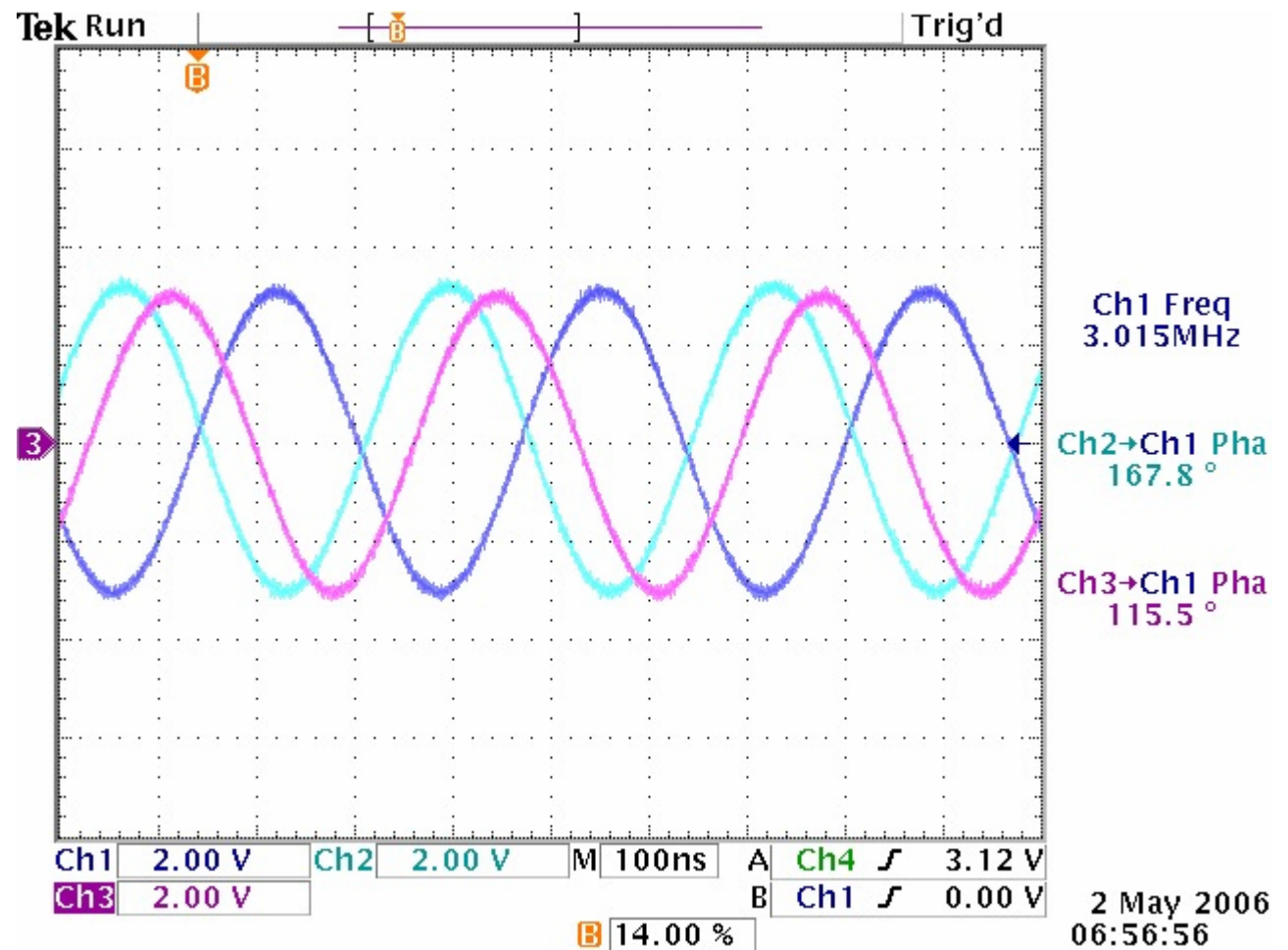
## The Third Cavity RF System

- Cavity to Cavity Phase Control

CH1: L2 Gap Voltage

CH2: L5 Gap Voltage

CH3: L6 Gap Voltage



# The Third Cavity RF System

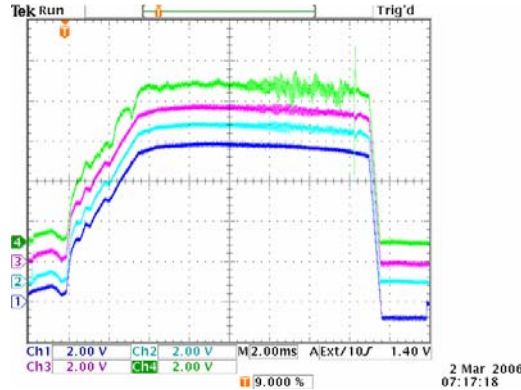
- Time Line (continued)

**March 1, 2006:**

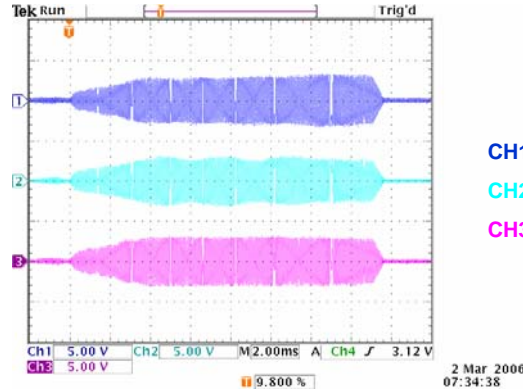
**Implemented L2-L6 cavity phase control and operated all three cavities with beam (> 24kV total).**



Before retuning

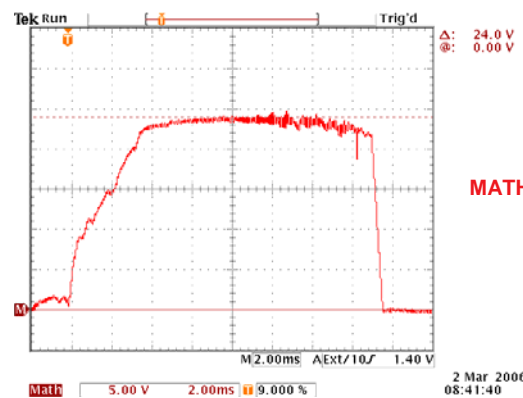
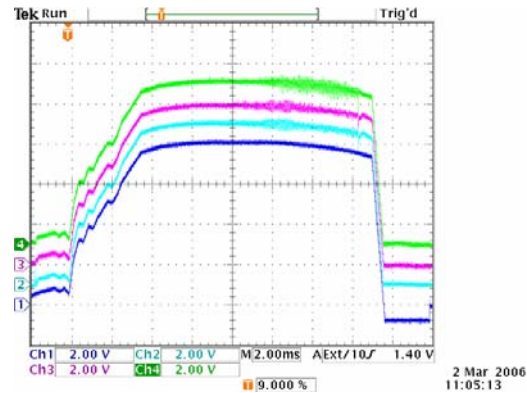


- CH1: Gap Voltage Program
- CH2: L2 Rectified Gap Voltage
- CH3: L5 Rectified Gap Voltage
- CH4: L6 Rectified Gap Voltage



- CH1: L2 Gap Voltage
- CH2: L5 Gap Voltage
- CH3: L6 Gap Voltage

After retuning



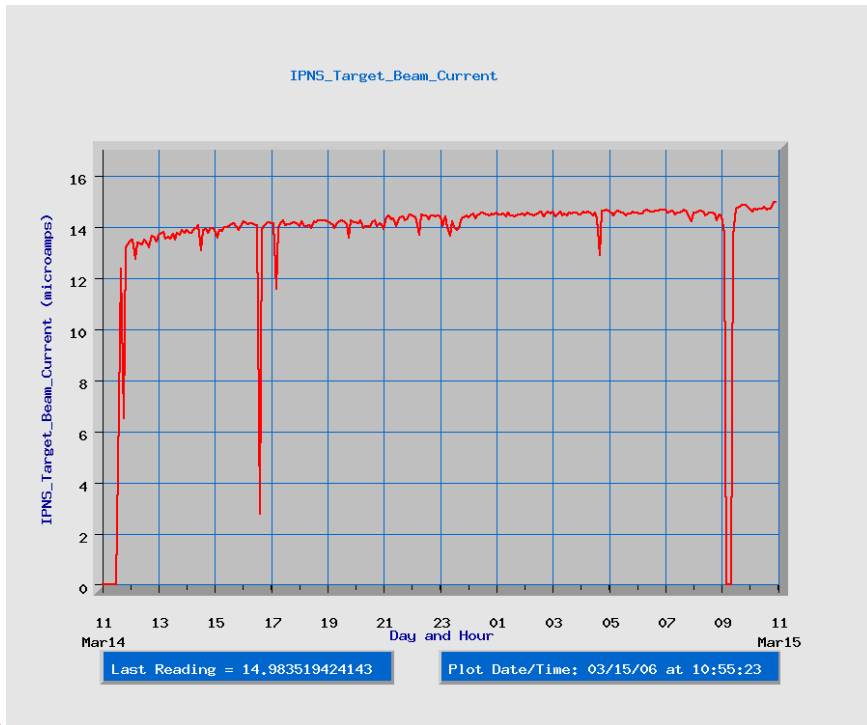
MATH: Total Gap Voltage



# The Third Cavity RF System

- Time Line (continued)

**March 14 – April 7, 2006:**  
**Three cavity operation.**



**IPNS OPERATING SCHEDULE - FY06**  
 October 2005 - September 2006

Indicates Run Period  
 Indicates Holiday  
 Start-up 15:00  
 Shutdown 10:00  
 Machine Res. 09:00 - 11:00  
 Machine Res. 09:00 - 15:00  
 Machine Res. 07:30 - 15:30



Month	Year	Days
October	2005	S M T W Th F S
November	2005	S M T W Th F S
December	2005	S M T W Th F S
January	2006	S M T W Th F S
February	2006	S M T W Th F S
March	2006	S M T W Th F S
April	2006	S M T W Th F S
May	2006	S M T W Th F S
June	2006	S M T W Th F S
July	2006	S M T W Th F S
August	2006	S M T W Th F S
September	2006	S M T W Th F S

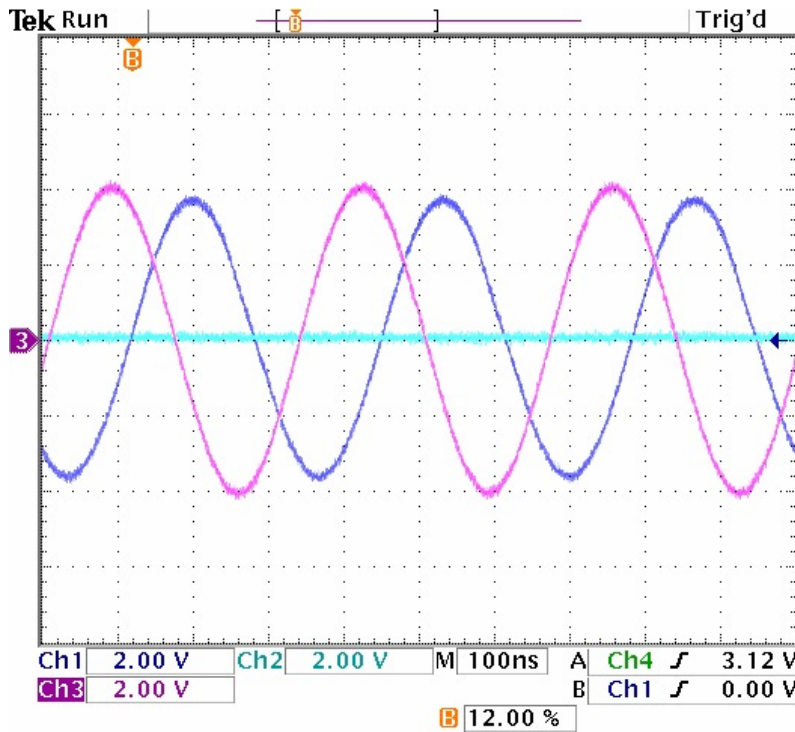
4/17/2006      FY06-24      (24 Weeks)

# The Third Cavity RF System

- Time Line (continued)

**April 4, 2006:**

**L2 – L6 operation with beam (~13.5uA).**



Ch1 Freq  
3.008MHz

Ch1→Ch3 Pha  
-114.7°

CH1: L2 Gap Voltage

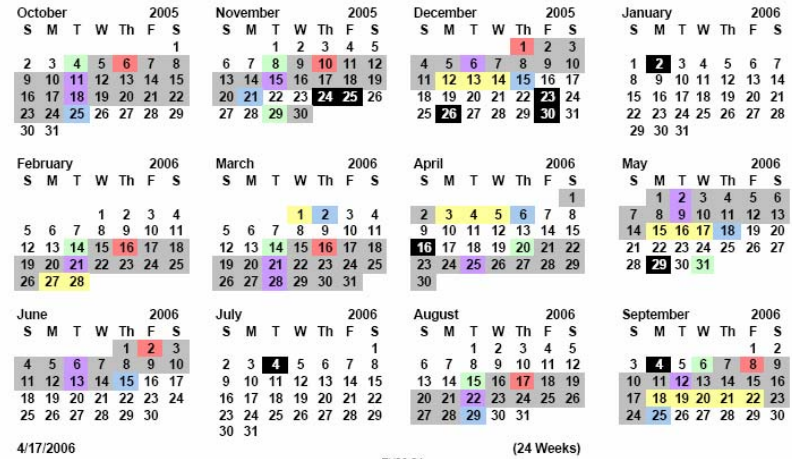
CH2: L5 Gap Voltage

CH3: L6 Gap Voltage

4 Apr 2006  
13:01:37

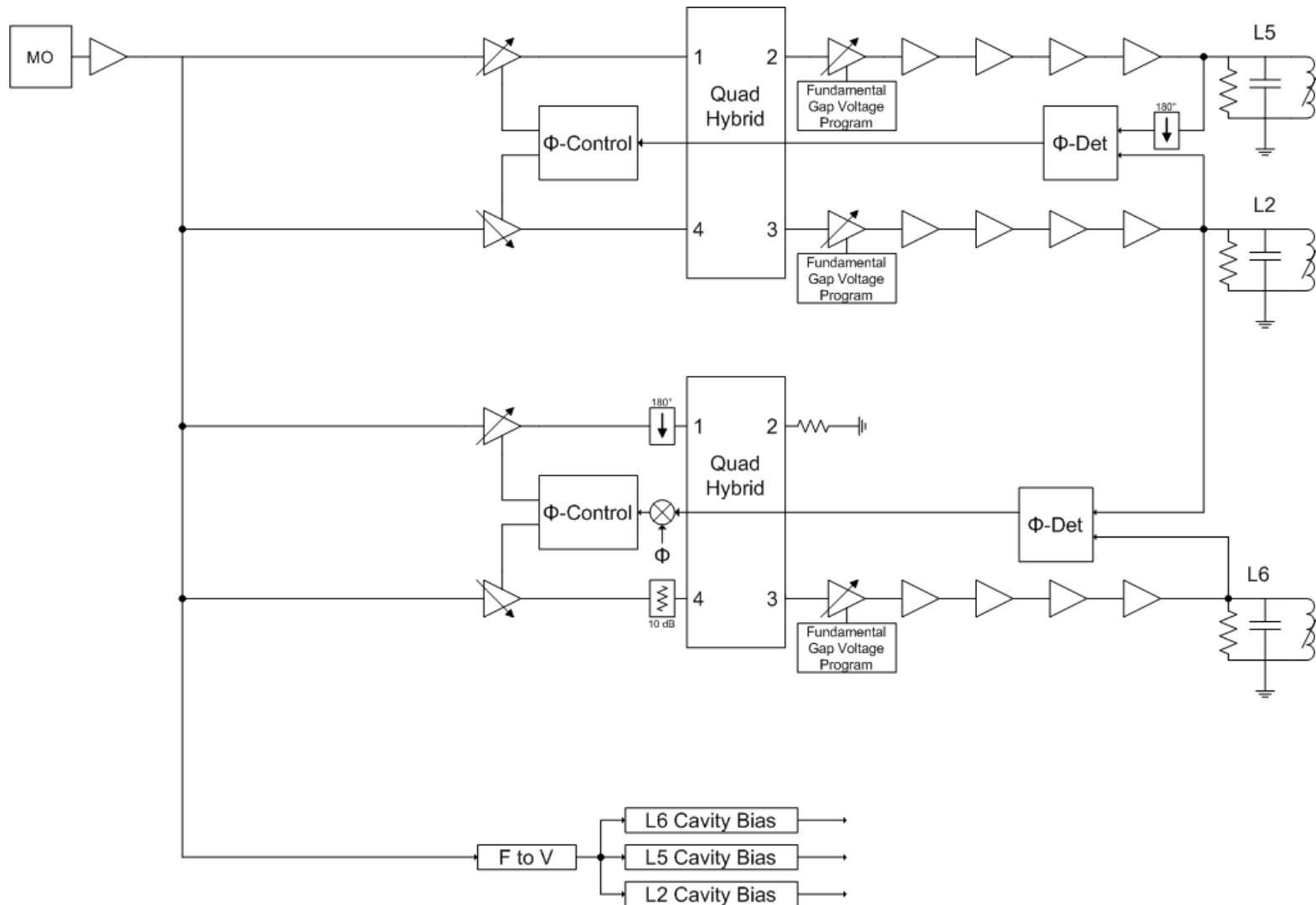
## IPNS OPERATING SCHEDULE - FY06 October 2005 - September 2006

- Indicates Run Period
- Indicates Holiday
- Start-up 15:00
- Shutdown 10:00
- Machine Res. 09:00 - 11:00
- Machine Res. 09:00 - 15:00
- Machine Res. 07:30 - 15:30



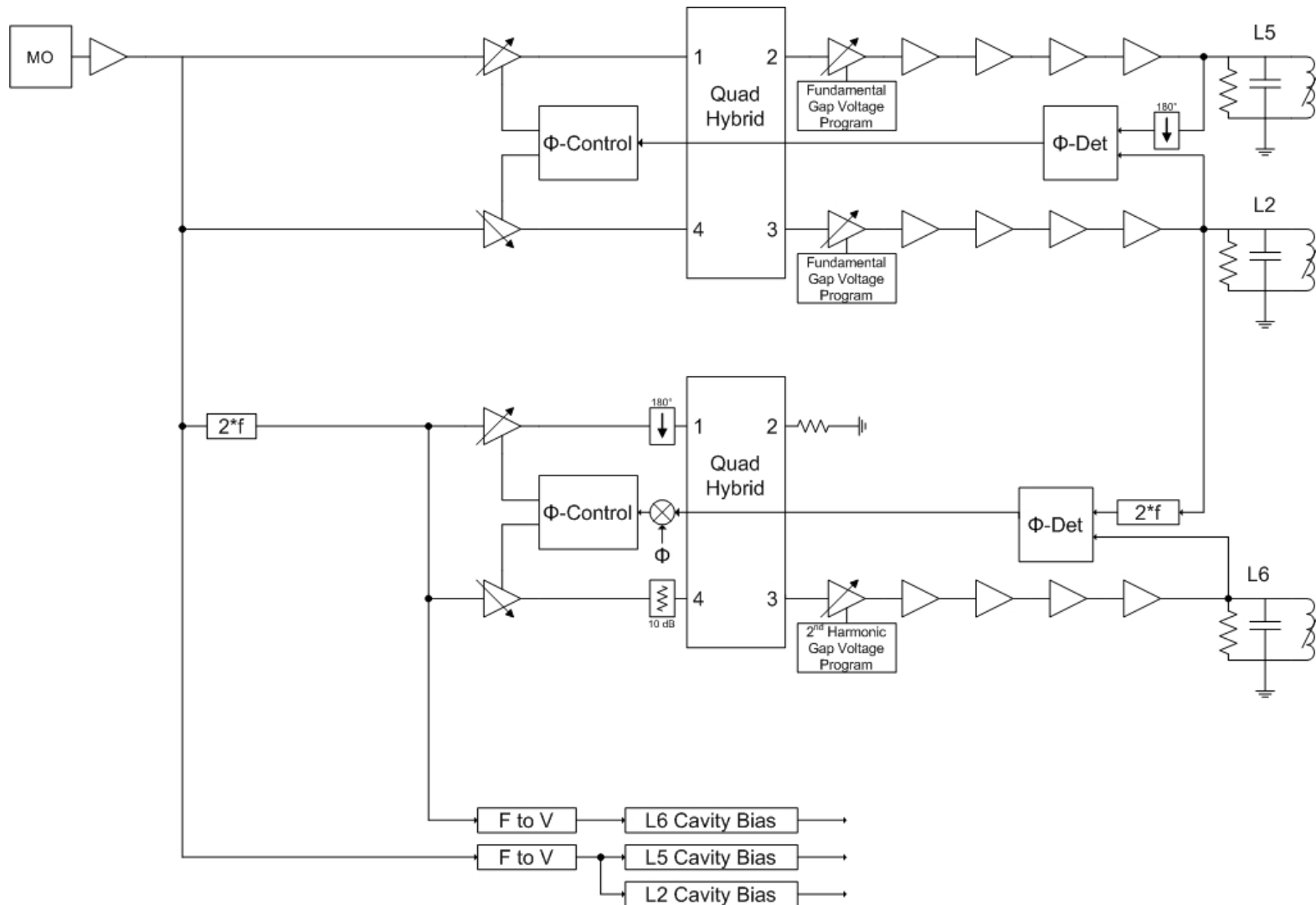
## 2nd Harmonic

- Fundamental Three Cavity Operation



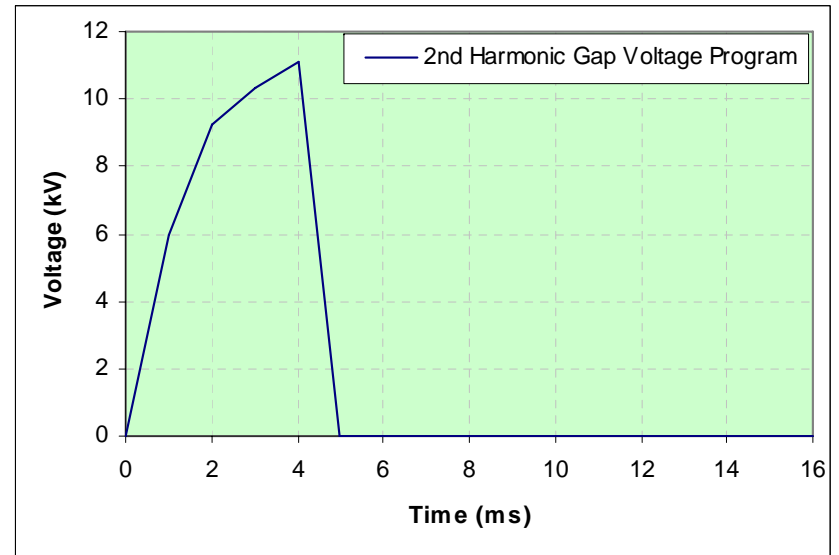
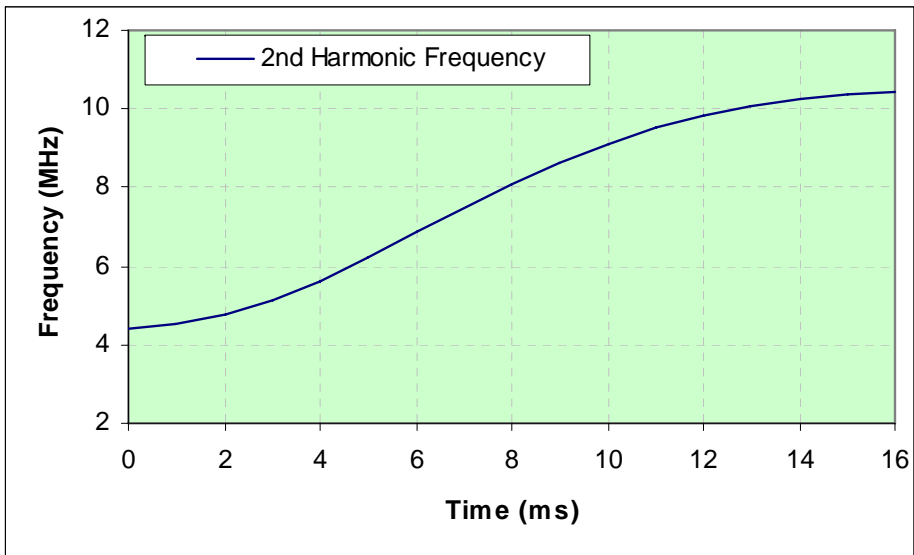
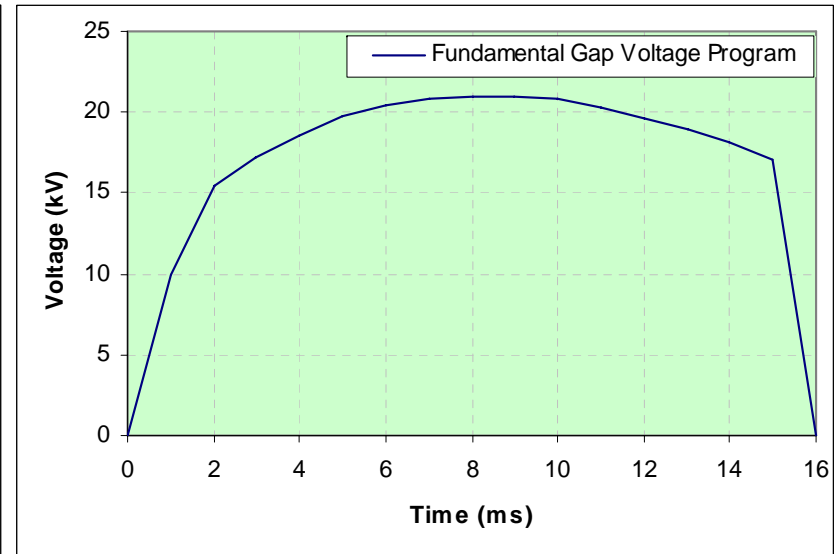
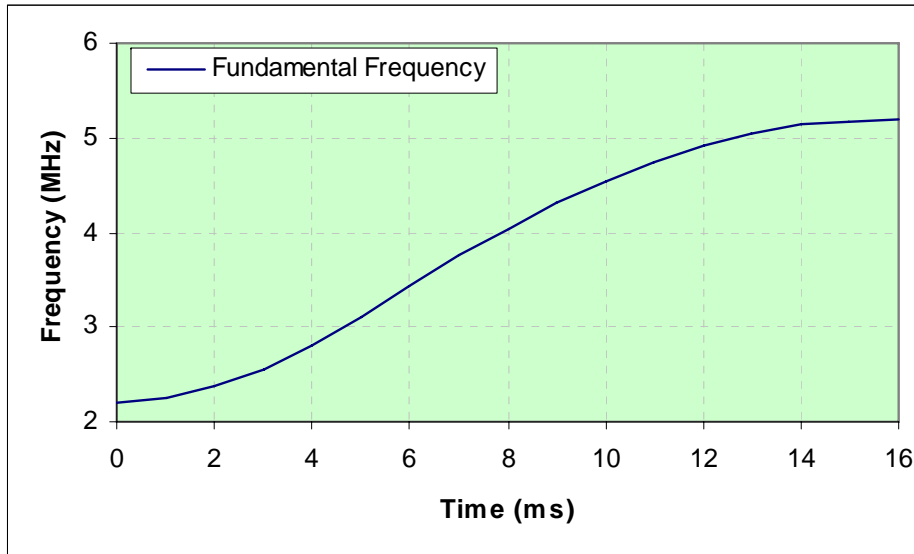
## 2nd Harmonic

- Minimum Second Harmonic Operation



## 2nd Harmonic

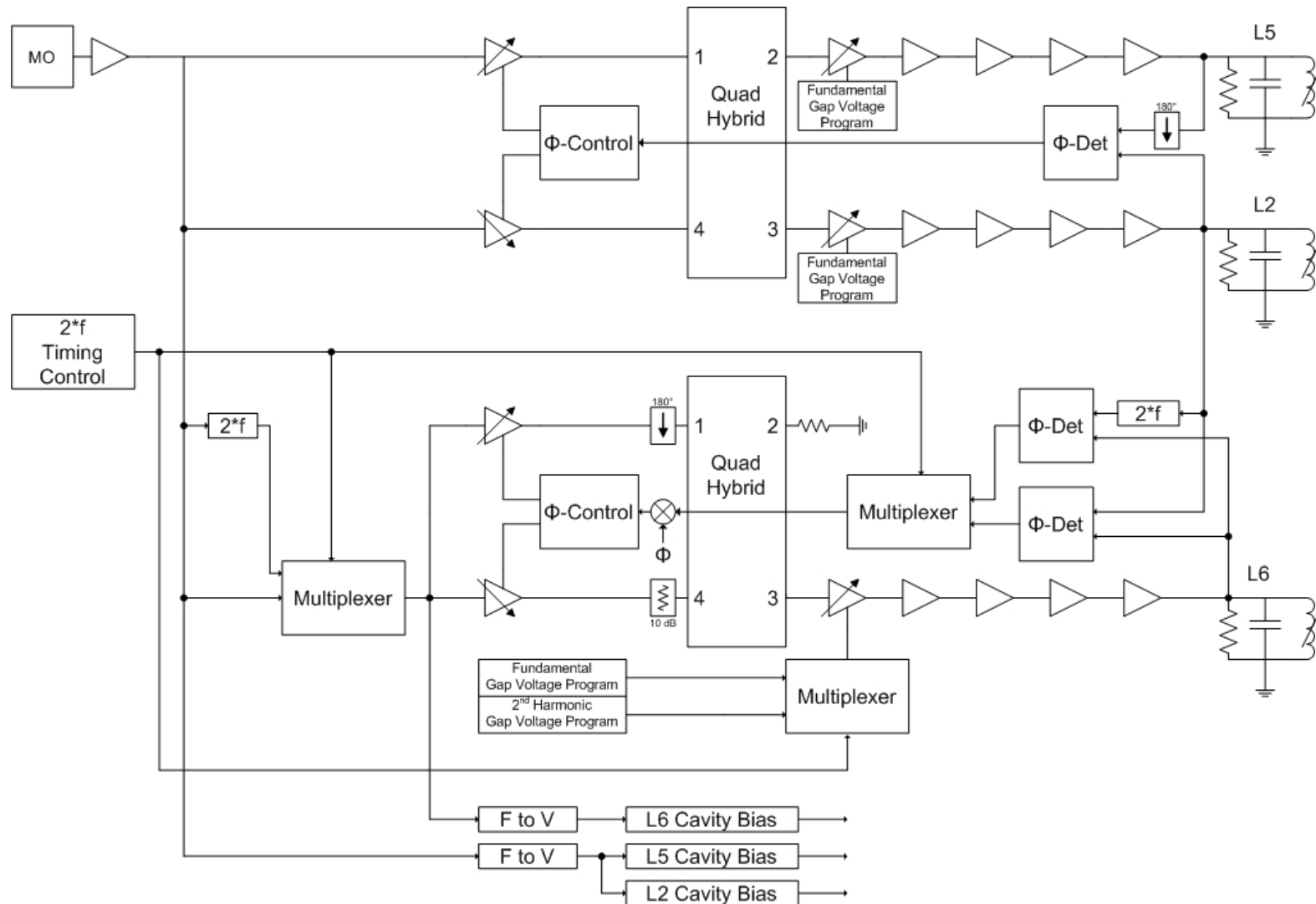
- Minimum Second Harmonic Operation





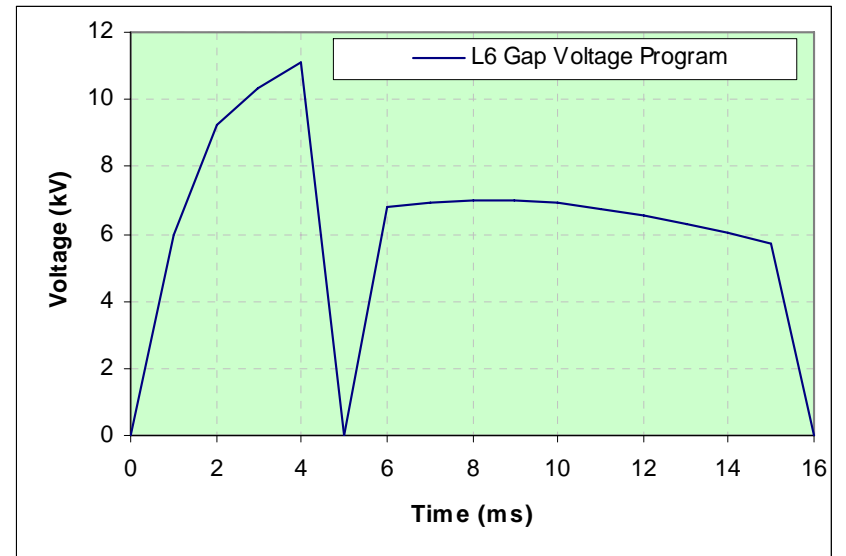
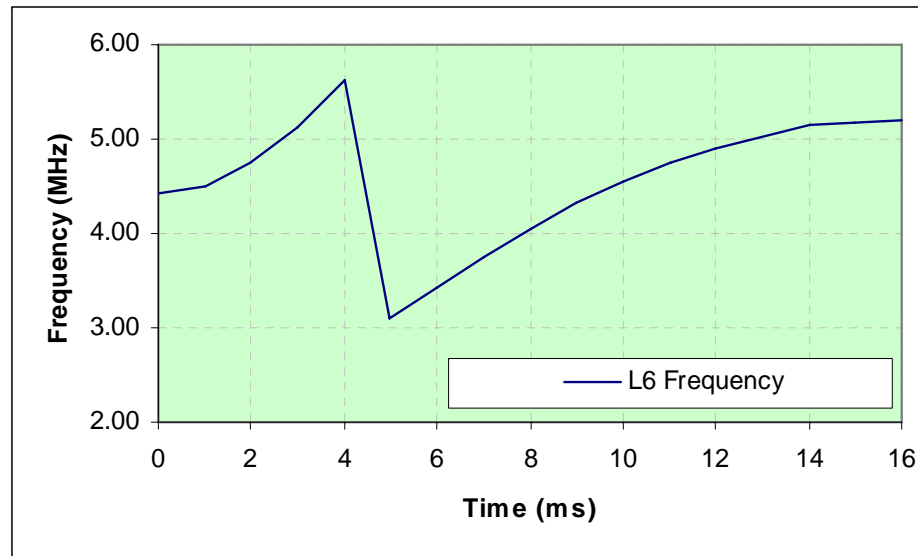
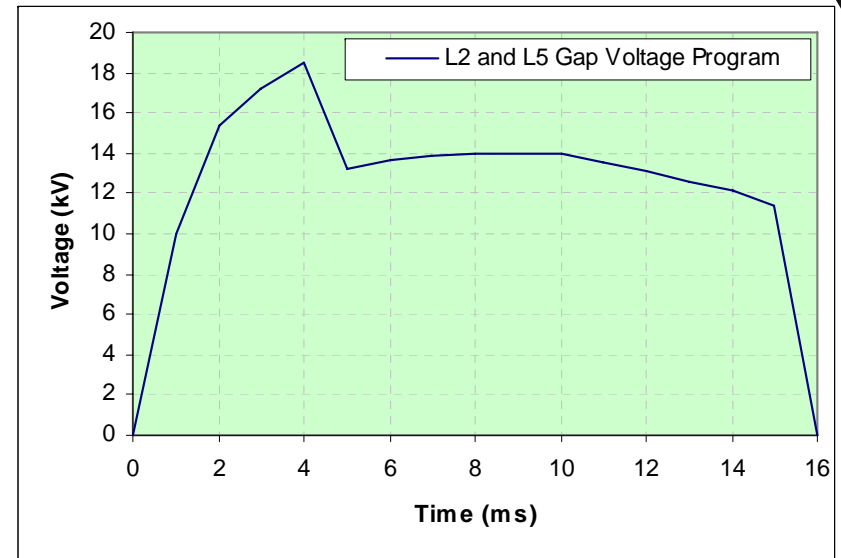
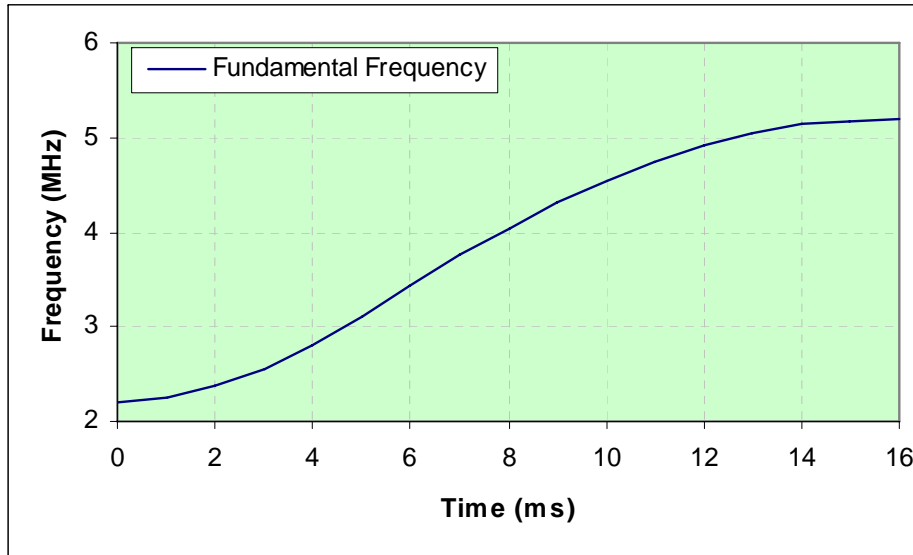
## 2nd Harmonic

- Second Harmonic Operation



## 2nd Harmonic

- Second Harmonic Operation



## Summary

- The third cavity has been installed and is operational.
- L2 – L6 cavity operation has been demonstrated, although not to satisfactory beam performance levels.
- L5 – L6 cavity operation has yet to be demonstrated.
- We have a platform for 2<sup>nd</sup> harmonic studies and hardware is being built.

